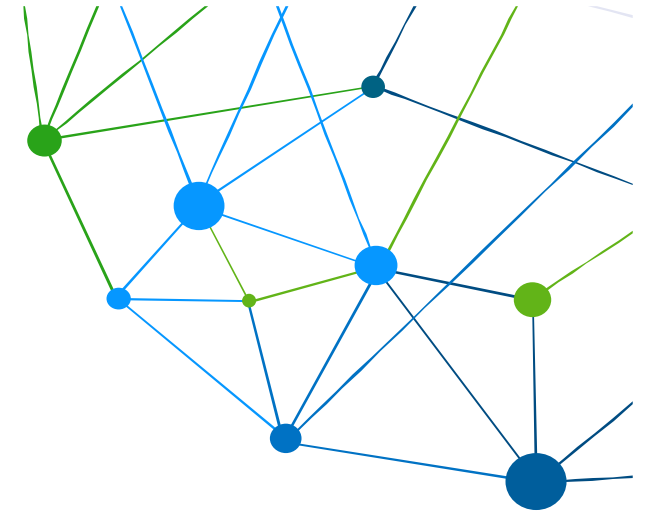


마이크로 LED 산업 및 기술동향

2019. 06. 21



Korea Photonics Technology Institute

μLED Display & Convergence Research Lab.

**Chief Researcher
Y.W. Kim, Ph.D.**

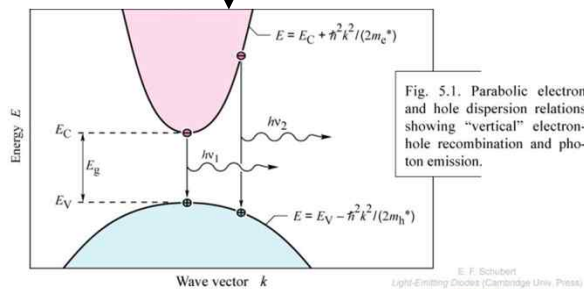
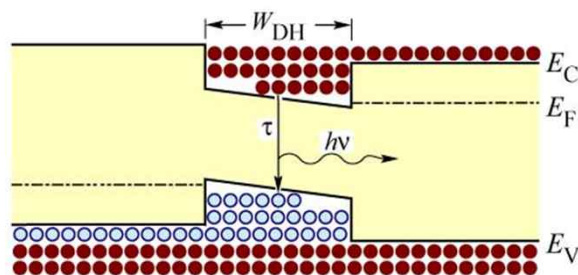
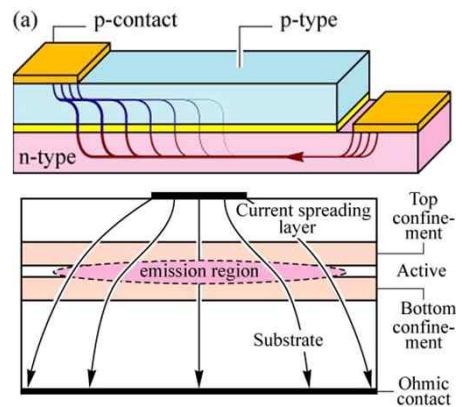
01 개요

2

마이크로 LED

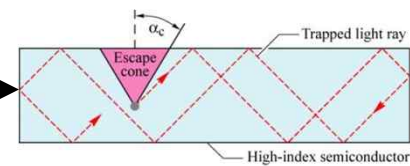
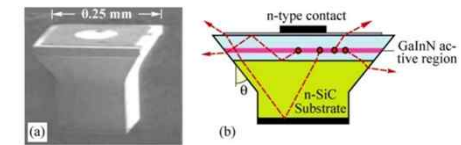
Efficacy Factor

$$\text{External Quantum Efficiency} = h_{\text{injection}} \cdot h_{\text{internal}} \cdot h_{\text{extraction}} \cdot h_{\text{PKG}}$$

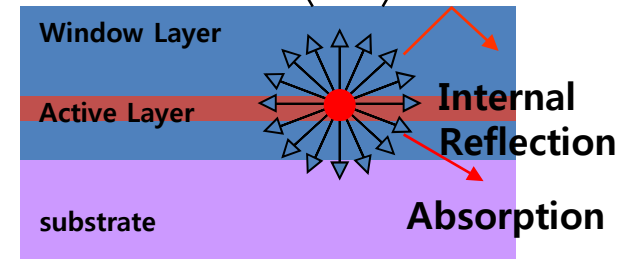


Epitaxial

Chip



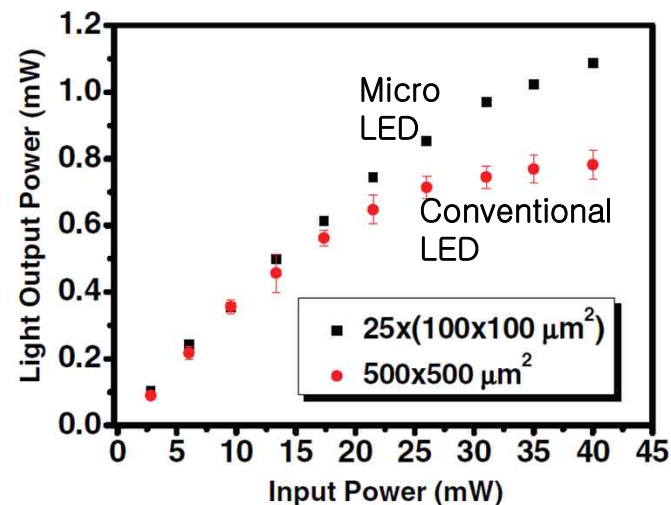
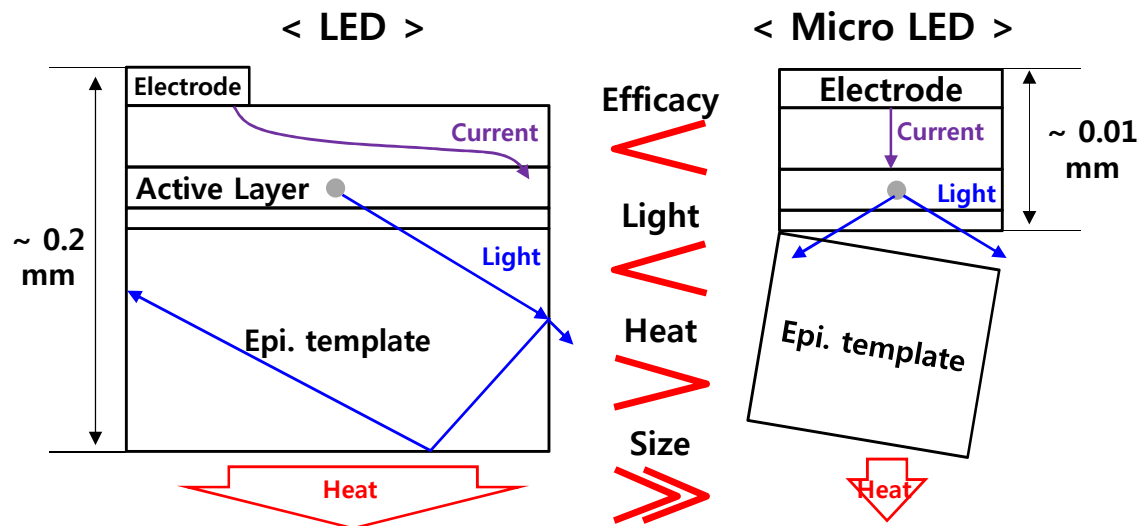
Epoxy



마이크로 LED

Higher Efficacy

- In the case of the conventional LEDs, the ray from the active layer is partially trapped in transparent sapphire substrate due to being out of an escape cone
- The extraction efficiency of Micro LEDs can't help being increased because of elimination of the epitaxial template, and also the lower stress of the epi. layer in processing the separation contributes to the higher efficacy
- The micro LEDs are extensively assembled on the PCBs or Backplane, and the lower heat flux in some area result in the improvement of the thermal effect



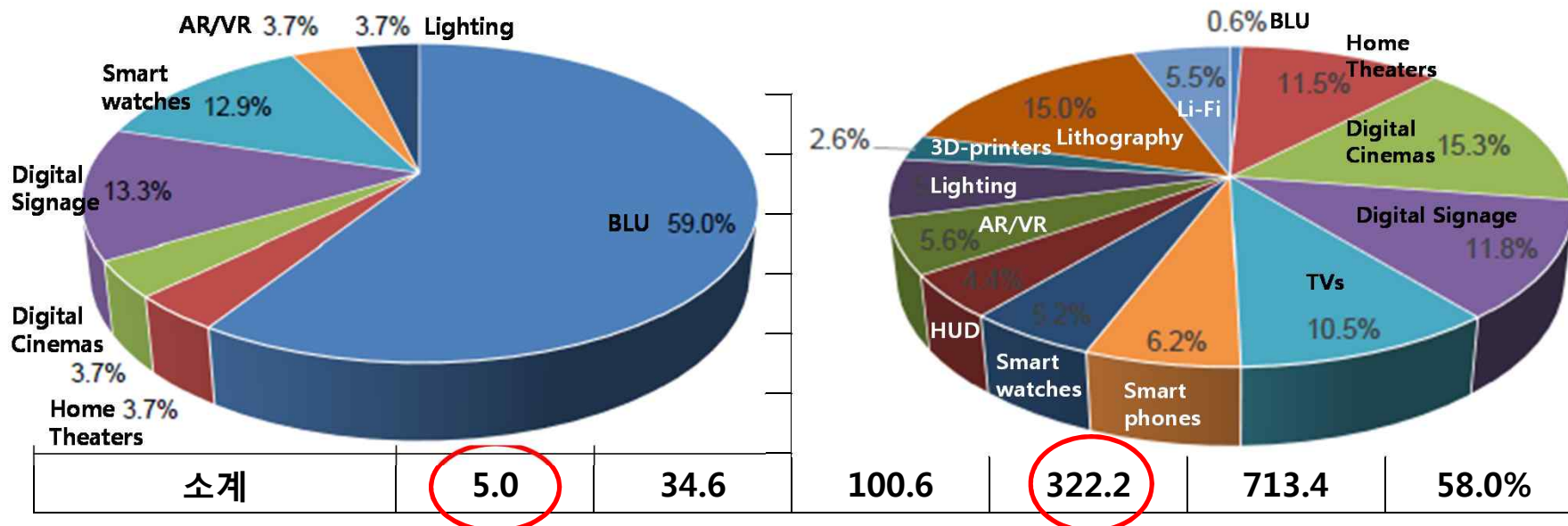
Reference : T.Kim, et.al., "High-Efficiency, Microscale GaN Light-Emitting Diodes and Their Thermal Properties on Unusual Substrates" small 2012, 8, No.11, 1643~1649

02 국내외 시장동향

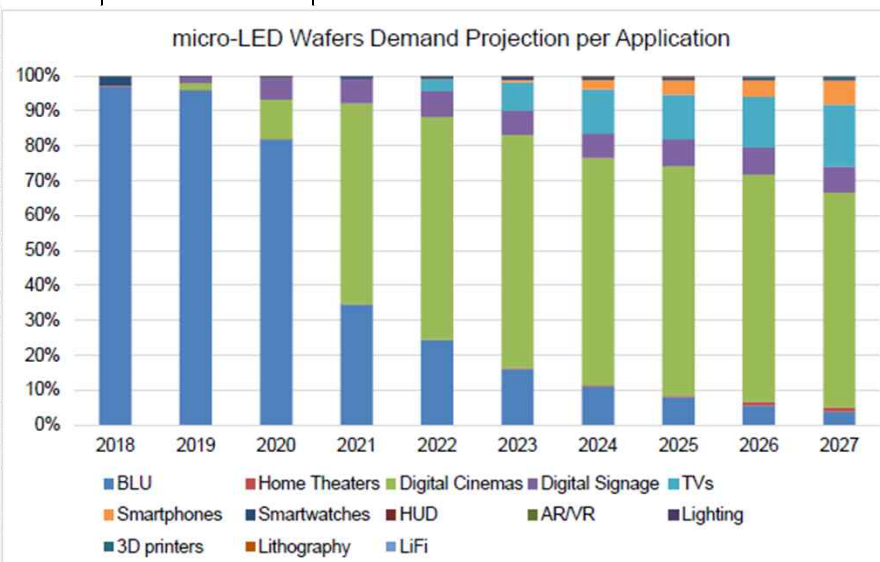
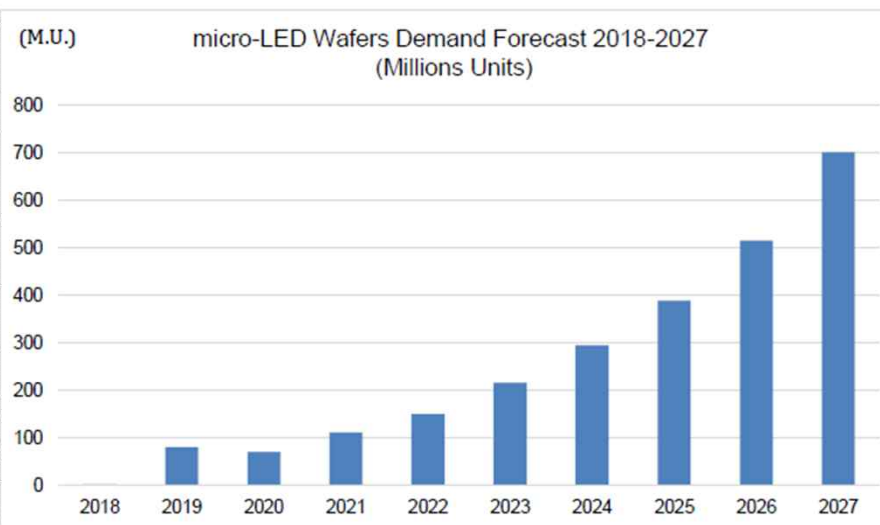
마이크로 LED

■ '18년 5억불 규모의 시장이 형성, 연평균 58.0% 이상 성장률로 '27년 714억불 이상의 시장으로 확대 예측

- 대형 디스플레이 신규시장은 건축물 내외장, 회의실, 상황실, 대강당 등
 - 기존 LED 광고판의 누적설치 시장은 200조원 이상으로 추산, AM방식으로 50% 이상 전환 예상
- 초소형 디스플레이는 야외에서 활용이 가능한 고휘도 저전력 제품에 적용
- 중소형 디스플레이는 스마트워치, 스마트폰, 자동차용 HUD 등에 '22년 이후 본격적으로 적용
- Emerging Market 분야는 자외선 및 적외선 파장대역의 마이크로LED를 적용하여 반도체/디스플레이 생산장비 후방산업과 의료/바이오, 통신, 3D 프린터 등에 다품종소량 맞춤형 생산 형태로 발전 예상



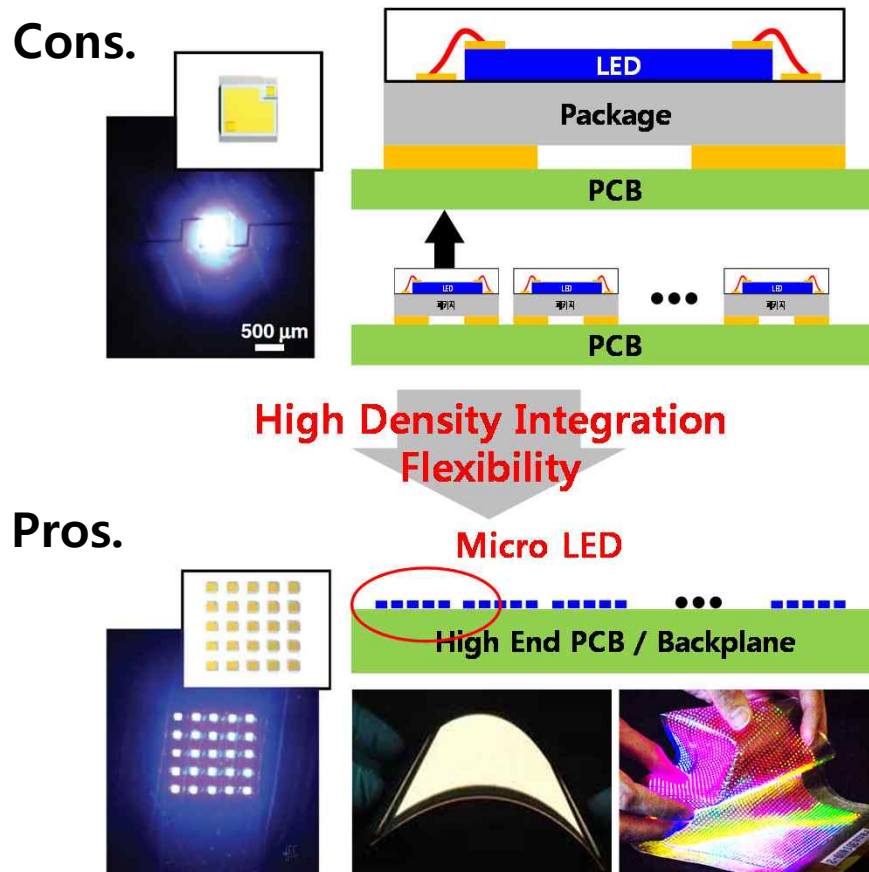
	'19		Penetr
	Penetration Rate (%)	Shipments (millions)	
BLU		20	
Home Theater	0.1	0.01	13
Cinemas	0.06	0.1	6.
Digital Signage	0.24	2	20
TVs	0	0	7.
Smartphones	0	0	5.
Smartwatches	11	5	81.
HUD	0	0	4.
AR/VR/MR	9	1	74.
Lightings	0.2	1	10
Lithography		0	
3D Printers	0	0	3.
Li-Fi	0	0	18.



02 국내외 시장동향

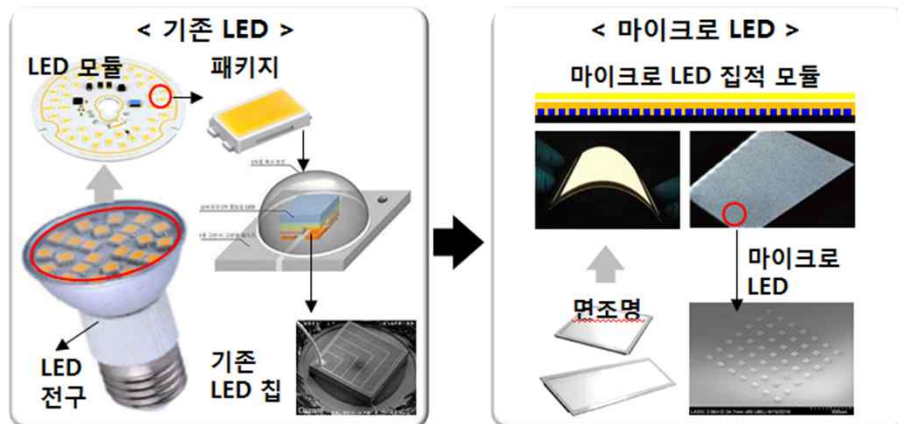
Applications : Display, Automotive, Lightings

- Core Technologies of Micro LED are compatibly Not only microminiaturization, but also Integration & Flexibilization for applications

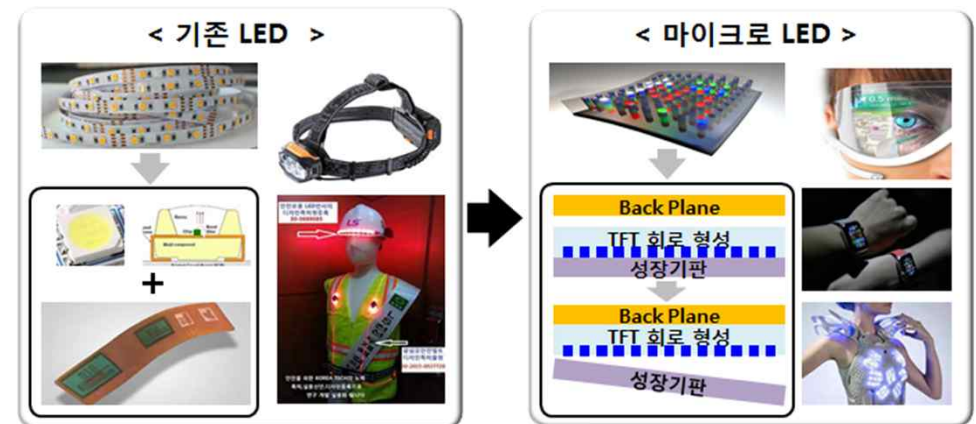


마이크로 LED 융합

[Lightings]



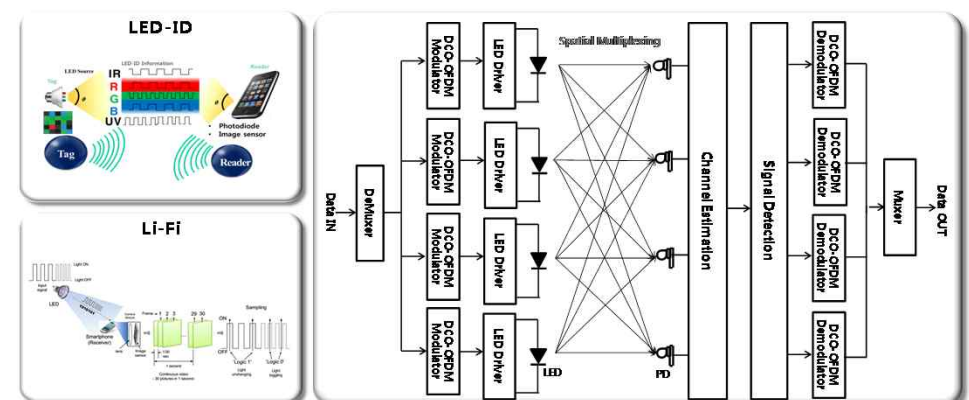
[Wearable]



[Drone/Robot]



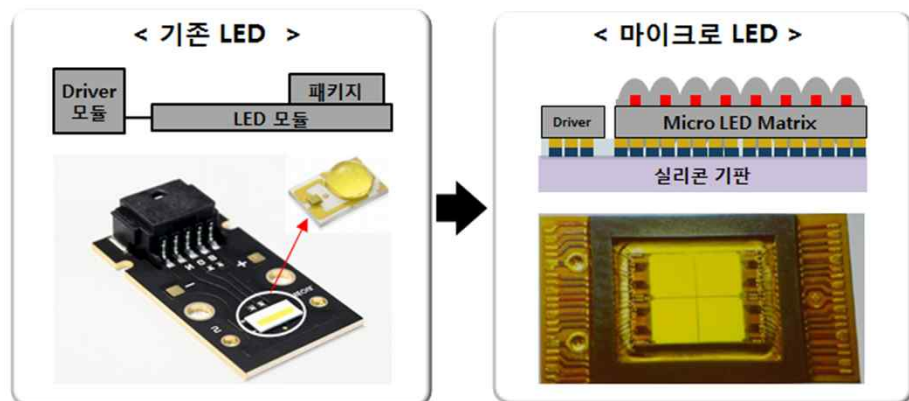
[Telecom.]



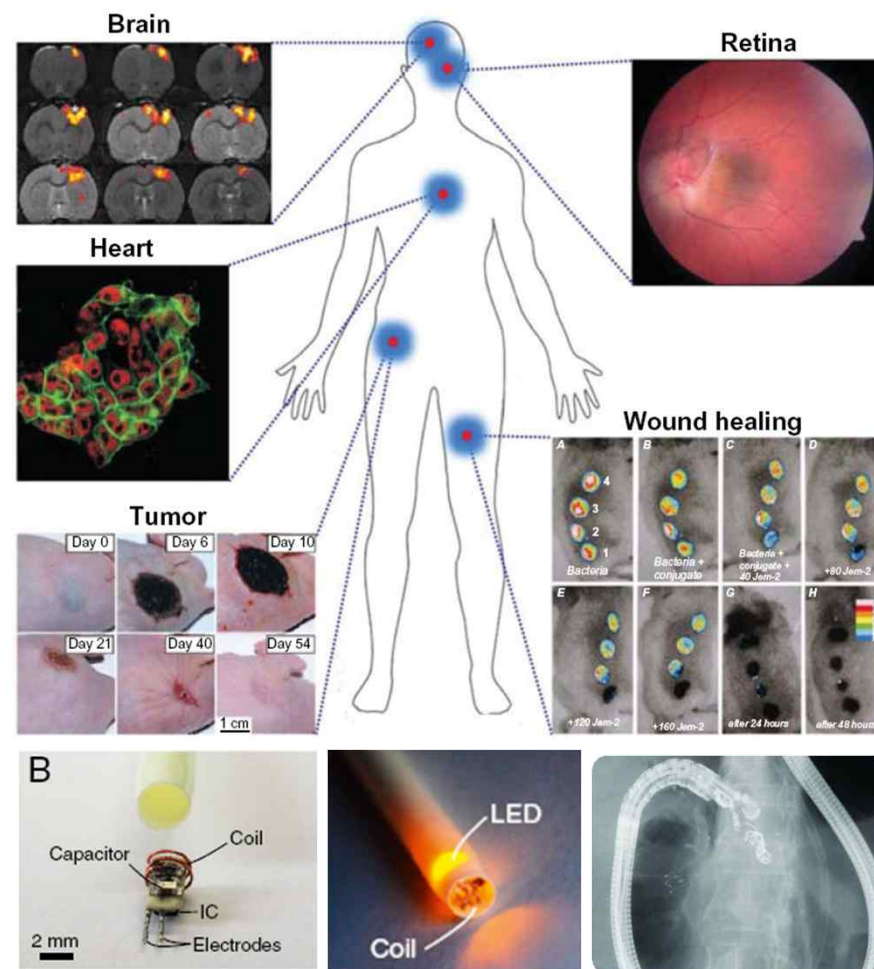
02 국내외 시장동향

마이크로 LED 융합

[Automotive – Headlamp, Lidar, Sensor]

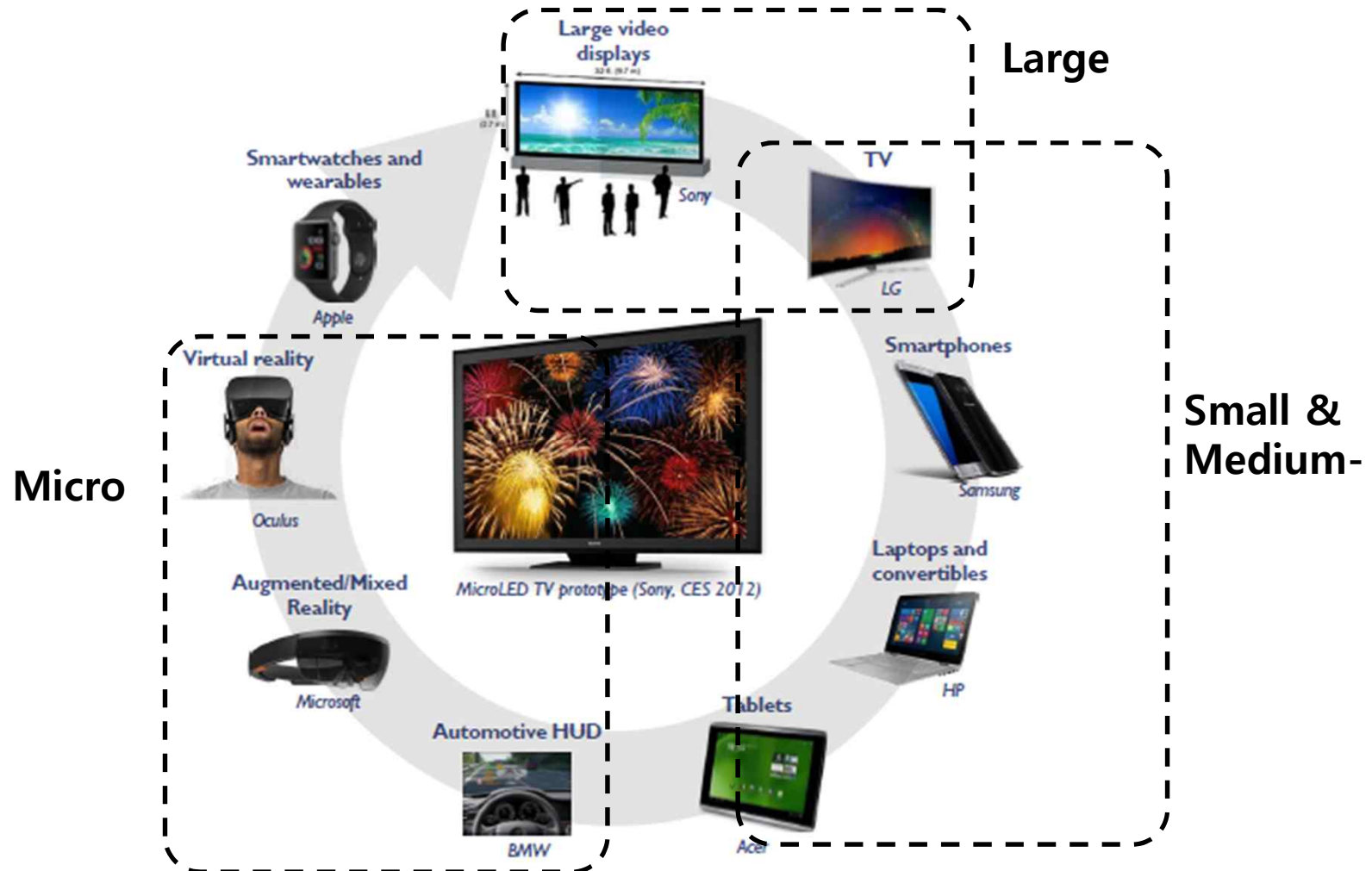


[Bio. / Medical]



02 국내외 시장동향

마이크로 LED 디스플레이



02 국내외 시장동향

초대형 디스플레이

■ 세계최초 적색/녹색/암갈색 LED 적용

- 1982년 일본의 아카미전기(현 JR 히카시닛폰)가 나리타역 호텔에 설치, 1993년 이후의 RGB 삼원색 LED 디스플레이 출시에 이르기까지 구동방식 및 제어회로 개발이 활발히 이루어졌음

■ RGB 삼원색 기술적용

- 니치아화학공업과 비스미디어와 공동으로 1994년 12월 후쿠이시에서 대형 영상사업을 하는 차량탑재형 영상장치(라이저울스)를 개발
- 오사카와 도쿄 빌딩 벽면에 대형 Full-Color LED영상을 설치한 미디어기켄과 아카미전기가 1995년 3월 도쿄 시부야 역에 영상제어기술의 성숙도를 높인 대형 빌보드를 설치 → 산업화 입증
- 미쓰비시, 마쓰시다 등의 대기업들과 미국, 유럽 및 한국 등의 기업들의 시장참여가 가속화

[슈퍼라이저 (아카미전기, 1995년)]



[11.2m × 66.4 m 터프비전 (미쓰비시, 2006년)]



02 국내외 시장동향

초대형 디스플레이

[Christie Velvet : MicroTiles]



[Mitsubishi 4K ChromaVision]



[Samsung SUHD 170" TV]



[Leyard 0.781 mm Pitch]



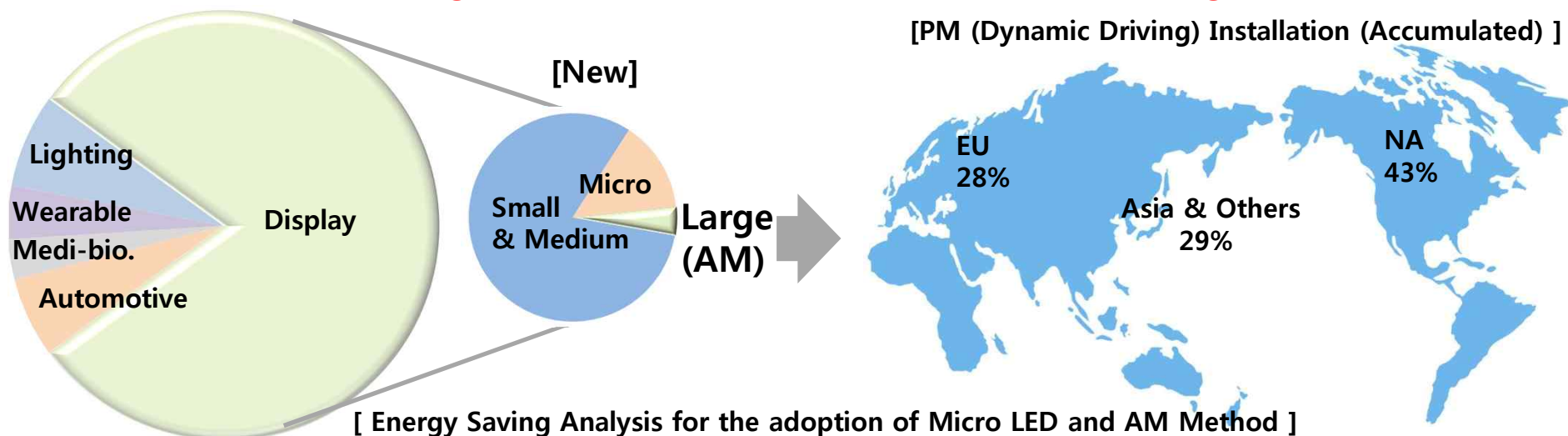
초대형 디스플레이

Industrial Potential of Large Display in the field of Micro LED Application

- New Market : Cinema, Conference, Education, Station, Hospital, Monitoring Room etc.
- Conventional passive matrix LED display : Too much power consumption

→ New Driving AM Method associated Micro LED (Paris Agreement of Climate)

[PM (Dynamic Driving) Installation (Accumulated)]



구 분	Save (%)	PWR (GWh)	Saved PWR (GWh)
Ultra Public Display	50	4,837	2,419
Automotive (Including Autonomous)	20	300	171.1
Mobile*	75	91.7	68.8
AR/VR*	75	91	68.2

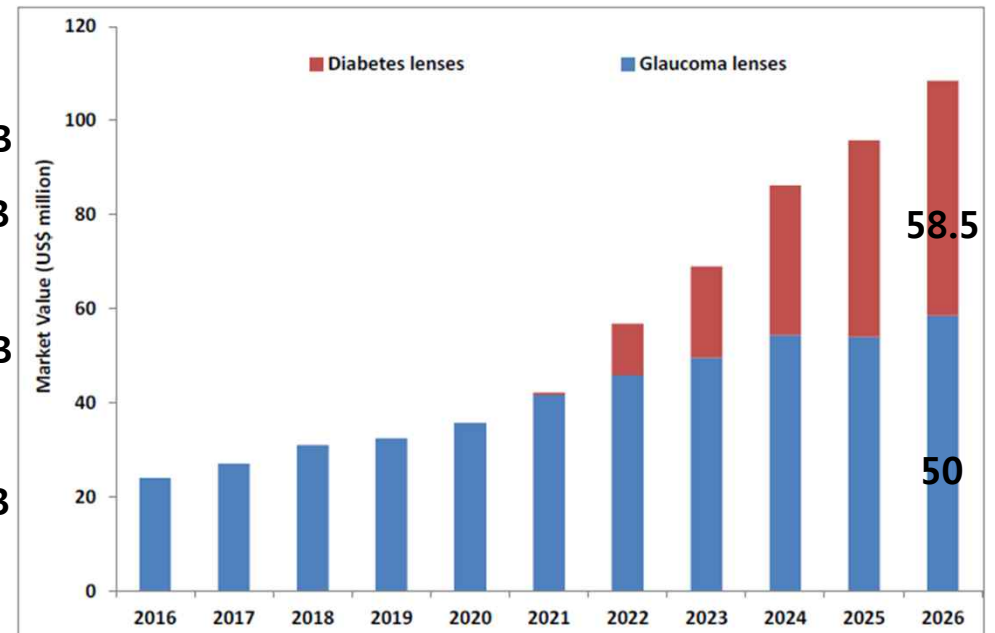
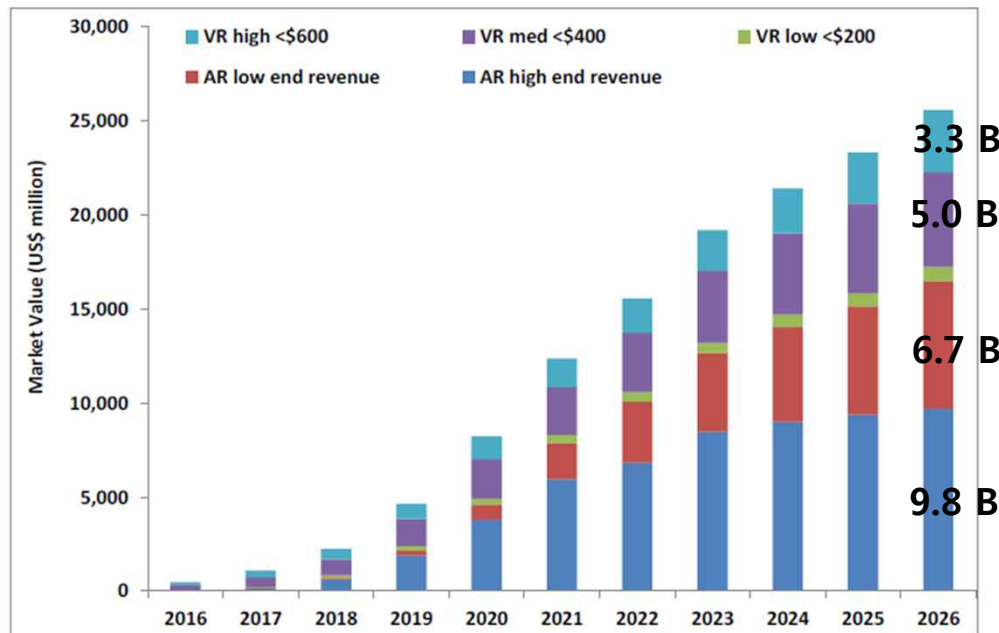
AR/MR/VR Market

- '26년 AR/VR 기기 시장 165 억불 / 90억불 전망 (Near-eye, On-eye Devices)
- High AR (MR) 98억불로서 시장점유율이 가장 높을 것으로 예측
- 웨어러블 의료/바이오 : Diabetes (당뇨병), Glaucoma (녹내장) 모니터링

Google (Soli), Microsoft (interaction software), Vuzix and Ahteer Labs (eye-worn computers)

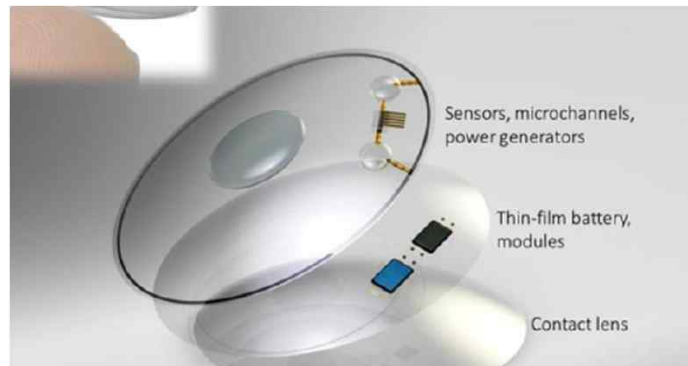
Challenges for Commercialization :
gesture recognition, eye-tracking

1. Power Supply (Form factor)
2. Flexibility (Design-ability)
3. Miniaturization (Integration)
4. Encapsulation (Anti-Moisture)

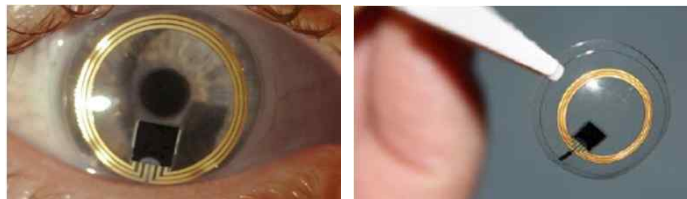


On-Eye Wearable

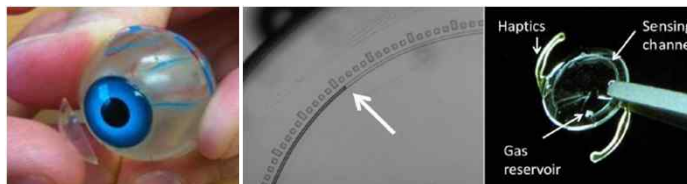
KIST → Diabetes Monitoring



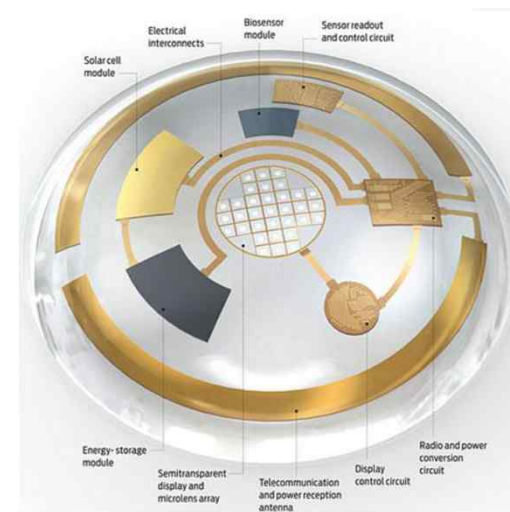
Sensimed AG → Glaucoma Monitoring



University of Michigan-Stanford Univ. & Bar Ilan Univ.-Auburn Univ.



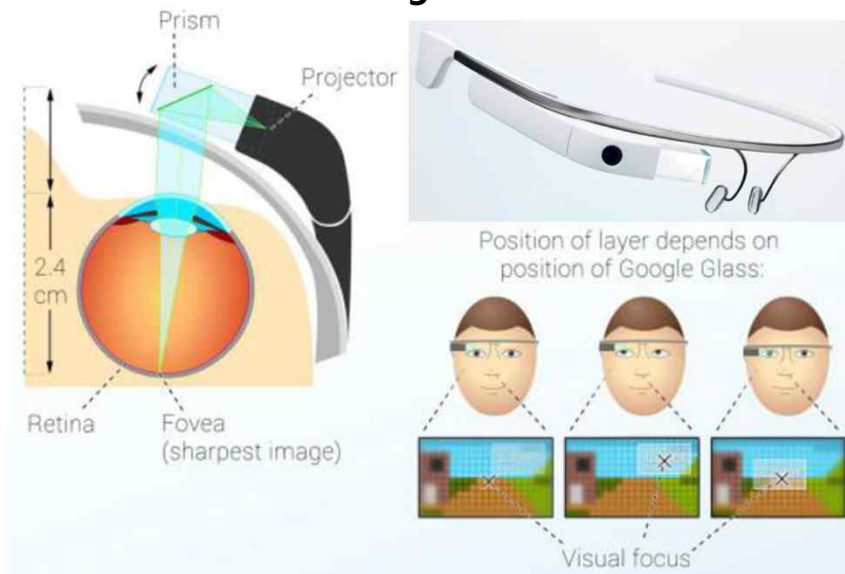
Google → Glucose Monitoring



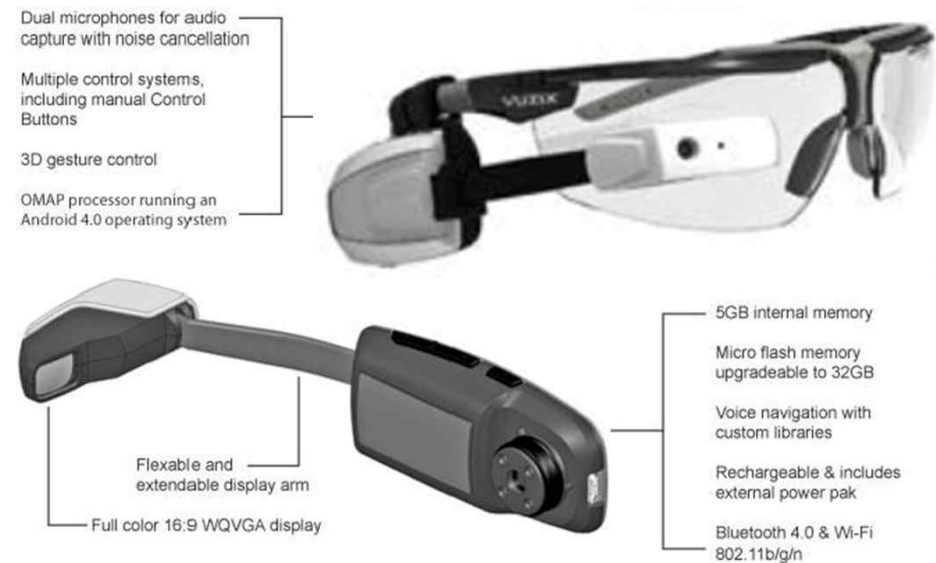
Antenna, Power-conversion, μ LED, Energy-storage, Biosensor

Near-Eye Wearable (AR)

Google Glass



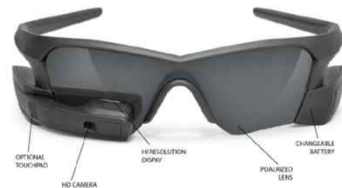
Vuzix M100



Epson BT-200



RECON JET



Optivent



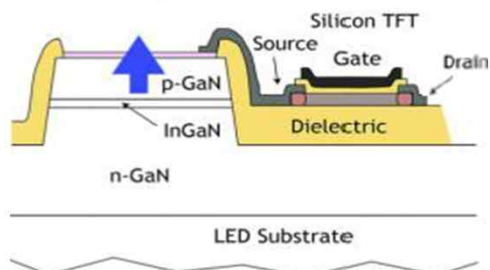
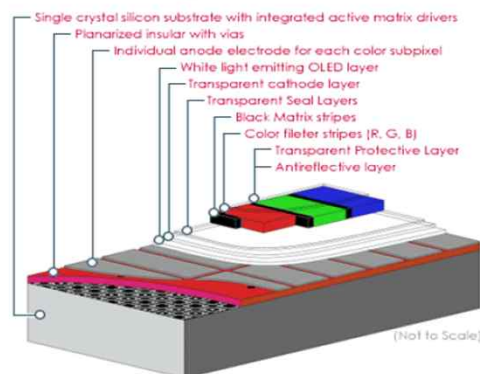
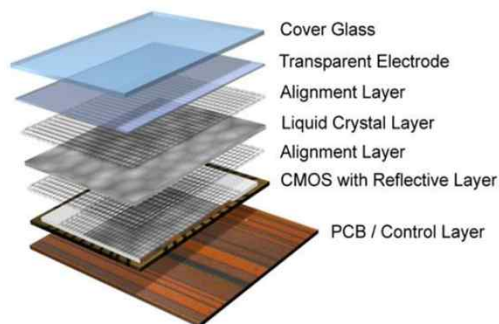
Hololens



Smart Eye Glass



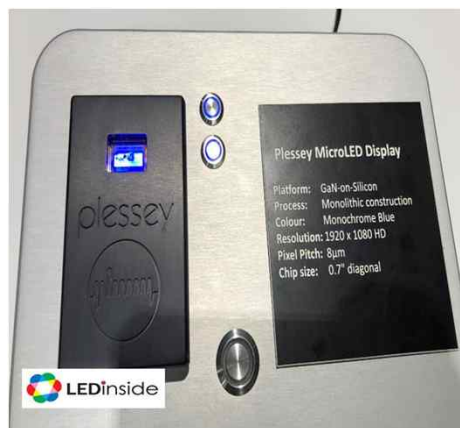
Near-Eye Wearable



Key factors	LCoS	OLEDoS	MicroLED	
Resolution (PPI)	> 6,000	~ 3,000	15~300	2,000 → 10K
Power consumption	1x	4.7x	0.5x	
Cost	100%	1000~200%	Too High	
Complete Chipset Readiness	◎	△	X	
Virtual Screen Size (FoV)	~ 90	~ 70	X	
Display Size (Eyewear Set Size)	0.2" ~ 1.2" (1x)	0.5" ~ 1" (1x)	2" ~ 1000" (NA)	< 1 "
Brightness (light source, nit)	30,000	~500	30,000	> 50K
Contrast Ratio	>500	>1,000	>1,000	> 3K
Screen Door Effect (fill factor %)	> 91	< 30	<< 30	
Optic Compensation	◎	X	X	OK
Technology/Product Readiness	Matured	Emerging	Early	

Near-Eye Wearable **SID 2019**

[Plessey Semi._UK]



- AR application
- 0.7" with 8um blue LED chips on JDC CMOS backplane
- 1920 x 1080 resolution

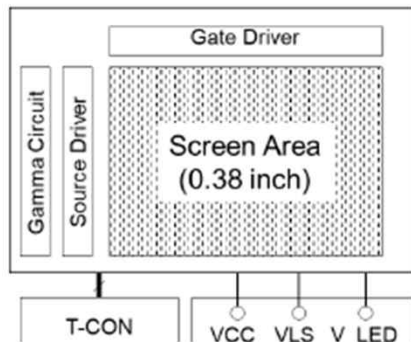
[Jade Bird Display_UK]



- 600 dpi bi-color(R/G) uLED with transferring technology.
- Mono-color : 5000x4000 with a million nits.
- Minimum pitch : 2.5um (mono-chrome)
- 5,000 PPI Try

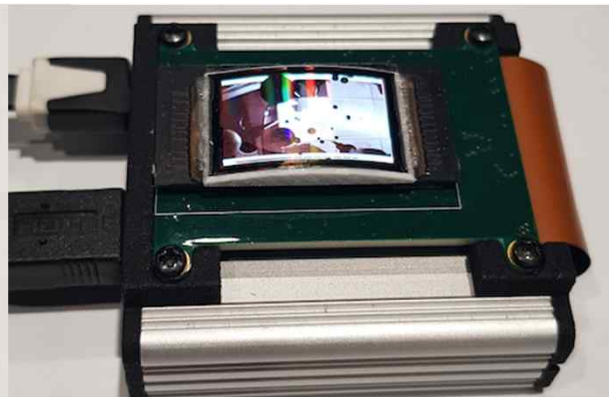
Near-Eye Wearable **SID 2019**

[Sharp (Japan)]



- AR application
- 0.38" , 1,053 PPI
- 209,088 sub pixel
- 1,000 nits

[LETI]



- 2,000 PPI, Mono-/Full-Color
- Hybridization
- 100K nits
- If AR optics efficiency is 10%, brightness of see-through type display will be over 10K nits

02 국내외 시장동향

| Near-Eye Wearable **SID 2019**

[eMargin]



- Micro-OLED
- 1920 x 1080 FHD
- 0.66-inch
- 2,000 nit
- 3,500 PPI

[BOE]



- 0.39" - 1920 x 1080 FHD
- 500 nit
- 5,644 PPI

02 국내외 시장동향

Players

Apple



Smart Watch

개발완료, 양산?
LTPO 기술전환

Mikro Mesa

TVs

50 인치이상, 50
PPI 이하

Sony

SONY

VueReal



TVs

20 PPI

AR/VR,
6,000 PPI

AU Optronics



Automotive

12.1 인치 Full-
Color 디스플레이

Rohinni



R2R 전사

조명, 자동차

PRP Optoelectronics



AR/VR,

Pico Projector



Fluidic 전사

Foxconn 인수

PlayNitride



Stamp 전사

1,500 PPI

Plessey Semiconductor



AR/VR,

Pico Projector

JBD



AR/VR

5,000 PPI 개발 중
10,000 PPI 계획

Lumiode



AR/VR

N type TFT 적용
GaN Tr. 개발

Oculus



AR/VR

OLED 헤드셋
InfiniLED 인수

02 국내외 시장동향

Players



TVs, DID
30 PPI, 146", 75"
The Wall



초대형
디스플레이
'17년 개발착수



uLED 광원
개발 진행 ('16~)



TVs, PID
IFA 2018 초대형
디스플레이 출시



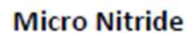
LED 광원
선도기업



세계 최대 칩제조
100 um 크기 양산



TVs, AR
139" 디스플레이
2600 PPI 단색



Nitride Semi.
자회사,
UV uLED 개발



RGB LED
AUO 자회사



GaN on Si
3D GaN LED



GaN 나노와이어
uLED 개발



RGB LED
100 um 크기 양산



대형 디스플레이
옥외/옥내용



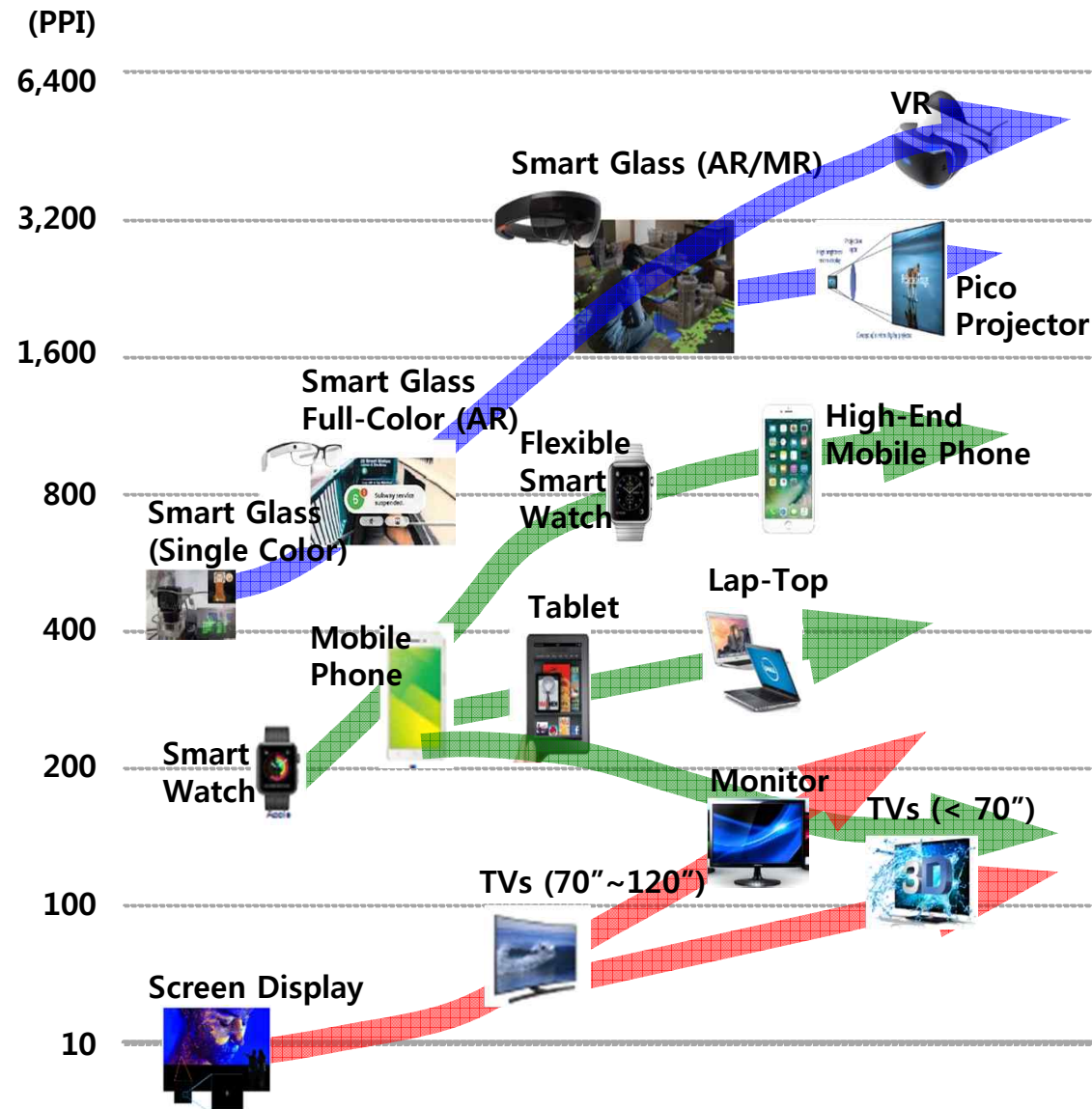
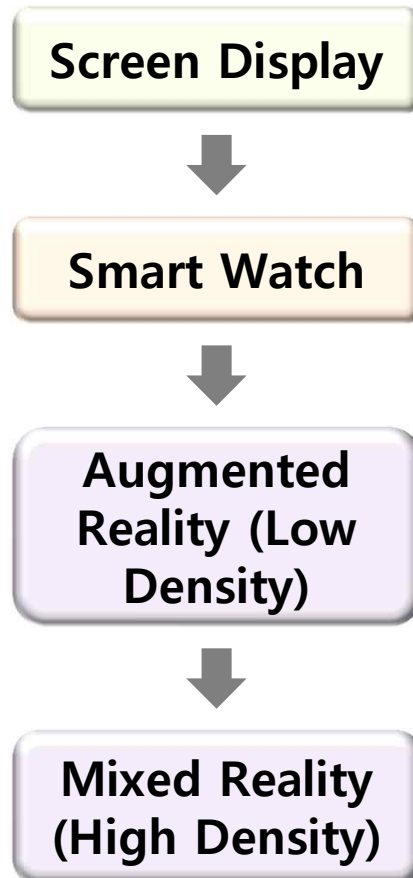
RGB LED
100 um 크기 양산



RGB LED
Foxconn 지분투자

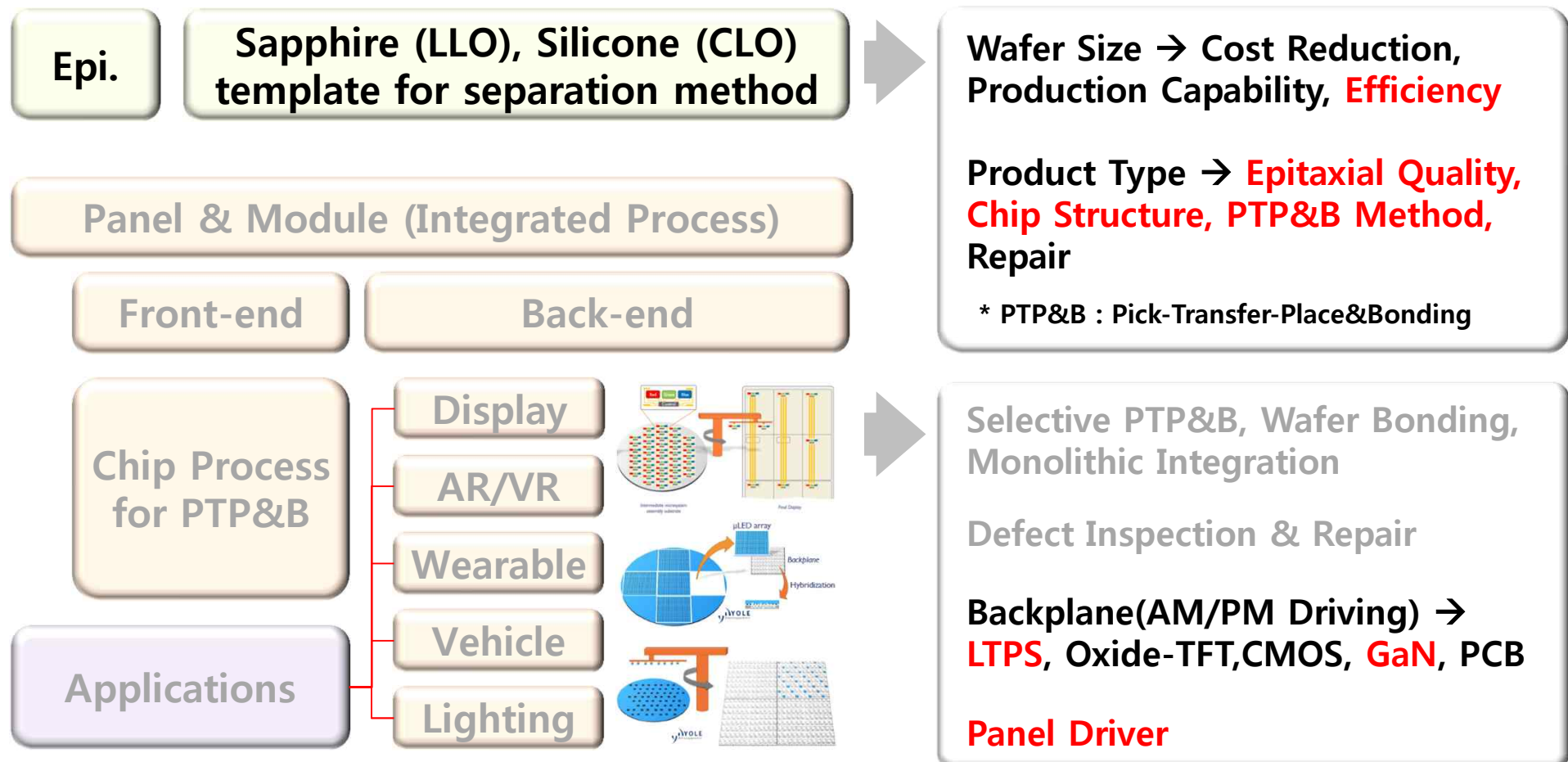
02 국내외 시장동향

Roadmap



Quality-Cost Factor

< Manufacturing Process >



Wafer / Epi. Quality-Cost Factor

Area Wafer Bonding
Monolithic Integration

AR/MR, HMD, HUD,
Smartwatches,

Selective Transfer
Pick&Place Bonding

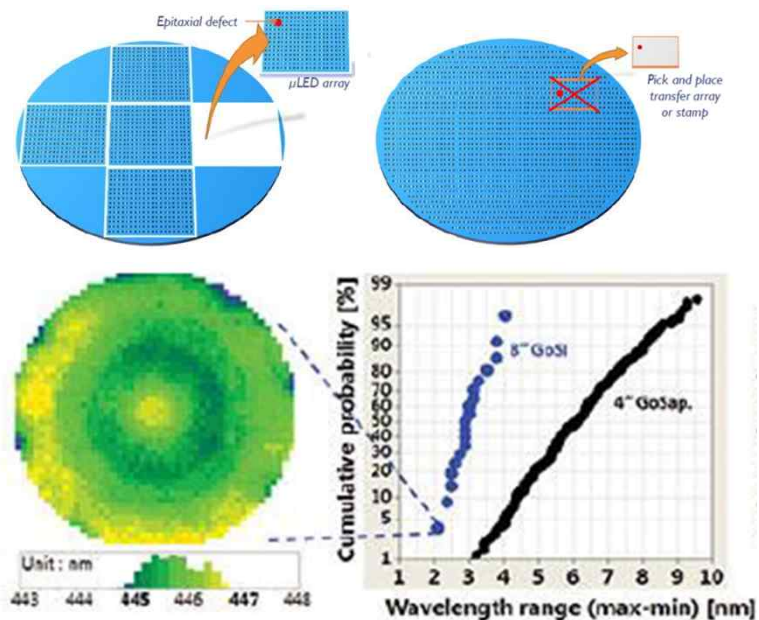
TVs, Smartphone,
Large Display

Quality Control

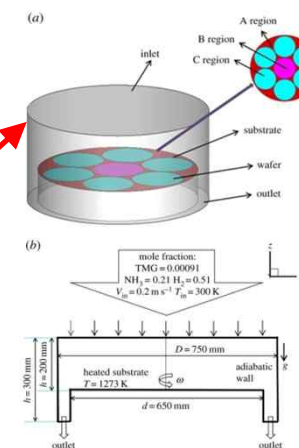
→ Single Chamber System

Epi. Level Inspection System

→ EL Detection Layer Formation



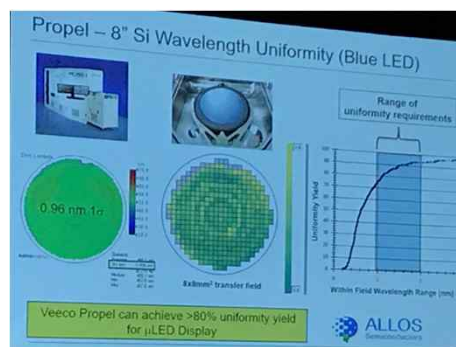
[Multi-Chamber System]



Wafer / Epi. Quality-Cost Factor

SID 2018

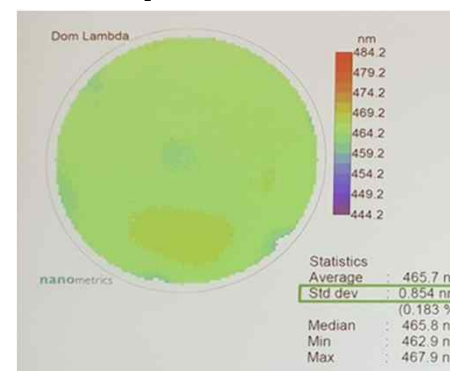
MOCVD : Veeco



- 6"/8" Wafer (4nm)
- Blue/Red : 80% / 95%
- Defect (0.8 μm) : 95%

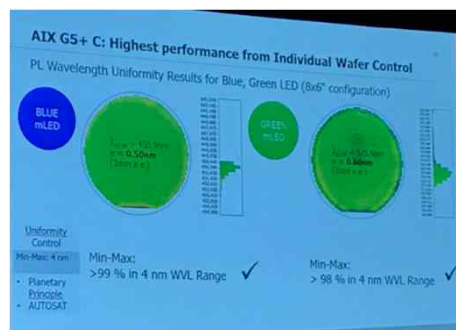
SID 2019

Epi. : ALLOS



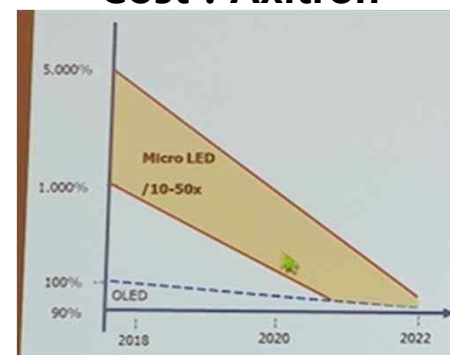
- 8" Wafer (2.5 nm)
- GaN on Si

MOCVD : Axitron



- 6" Wafer (4nm)
- Blue / Green / Red : 99% / 98% / 99%
- Cassette to Cassette automation

Cost : Axitron

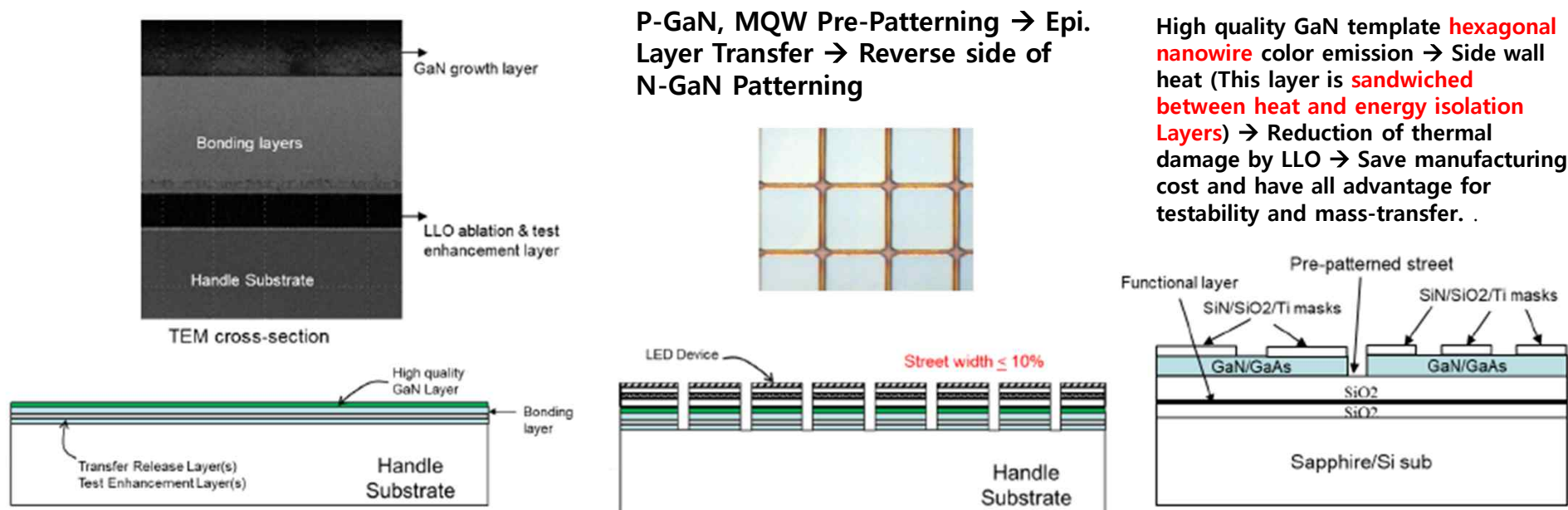


- 50X than OLED
- < 150\$ -4K, 75"

Epi. Template

Epi. Template for EL Test & Easy Transfer (QMAT)

- Multi-layers structure with an functional layer for testability and mass-transferability
 - QMAT high quality GaN and GaAs templates can have pre-patterns to define less than 5μm LED die size with street widths of about 1μm.
 - Reduction of Sidewall Effect → this ultra-fine patterning enhances stress control for epi growth and will result in better LED performance

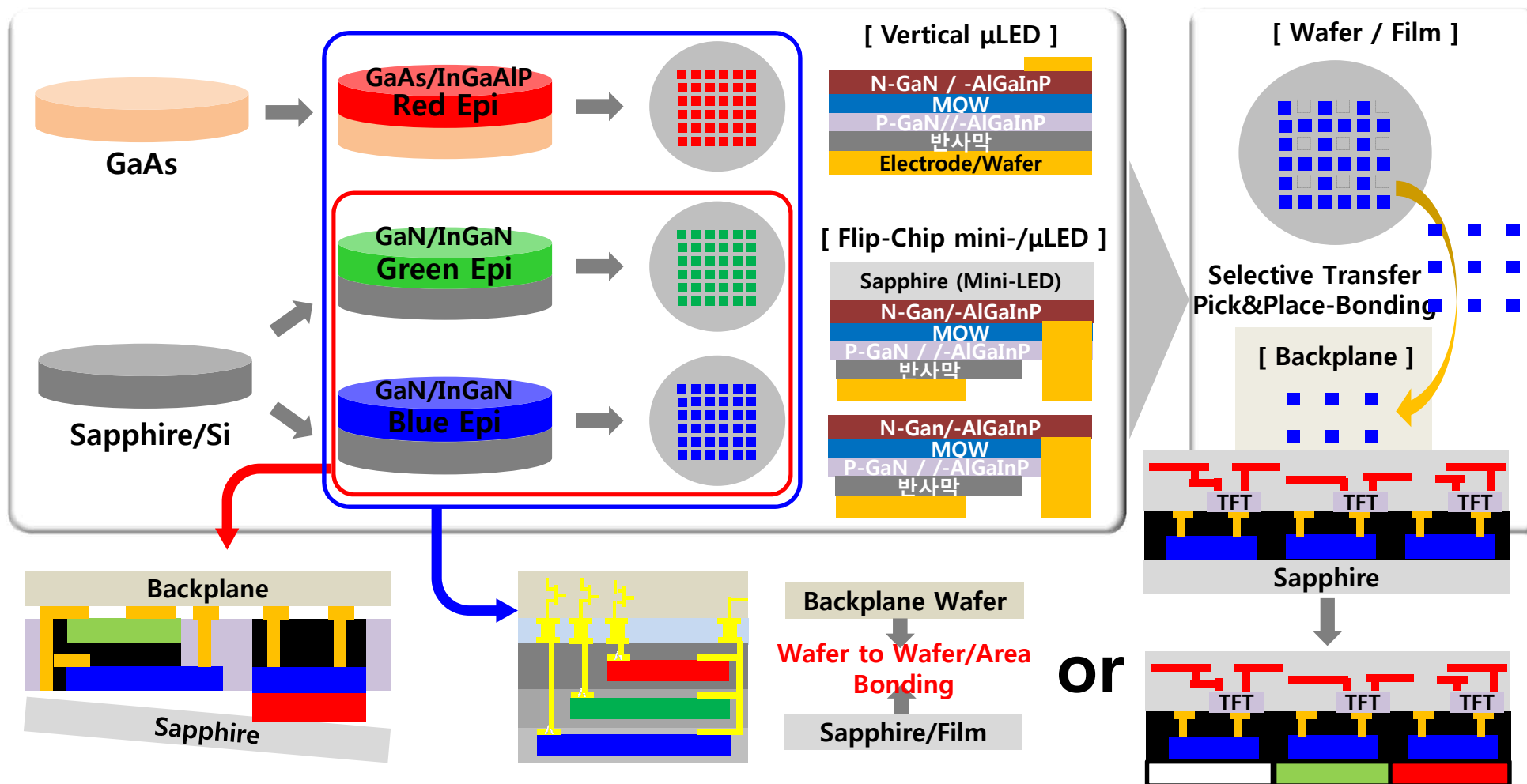


Reference : Dong Lee, et. al., "Ultra-Fine High Efficiency MicroLEDs with Testability and Transferability Using Layer-Transfer Technology" SID 2019, QMAT, Inc. Santa Clara, CA, Stanford University, Stanford, CA

03 기술동향

27

Pixelization



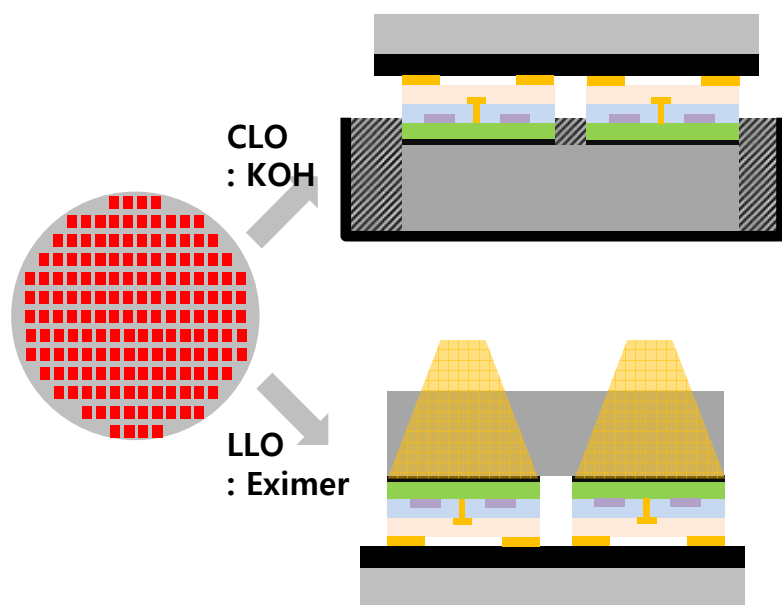
Pixelization

Associated with LLO/CLO Process

Trench Structure in sapphire substrate

- QD & Nano-Phosphor can be printed or dotted on Blue & Green Micro LEDs based on GaN
- Opaque Si or GaAs epi. substrate should be removed, and then attached film or sapphire substrate on the red epi. layer with color conversion materials.

[기판분리 공정]



[RGB 구현 및 트렌치 구조 형성]

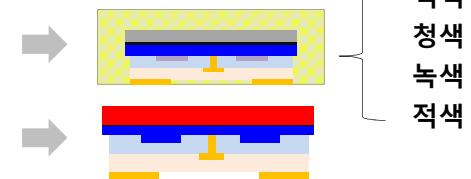
- 120 μm \times 240 μm RGB TFT- μLED 집적광원
→ 초대형 디스플레이, Emerging Market 직접응용



- 색변환 소재 적용 솔루션 (필름, 도포, 잉크젯)

형광체/QD CSP (Chip Scale Package)

형광체/QD Film + μLED -TFT 집적광원



- ICP / RIE를 적용한 투명 기판 트렌치 형성

나노형광체/QD 적용 디스플레이 모듈



Pixelization

1,053 PPI, 0.38 inch MicroLED+QD

MicroLED display bonded onto silicon driver → Near-eye Display (AR/VR, HMD)

- QD materials were mixed into photo-resist to be used for photolithographic patterning process.
- Inkjet Process : In dispersants, the additives, photoinitiator and curable resin are mixed together to activate photosensitive performance.

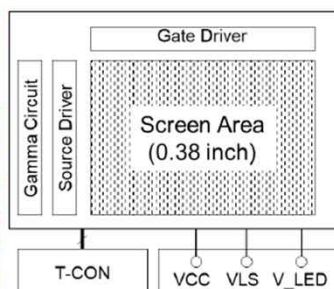
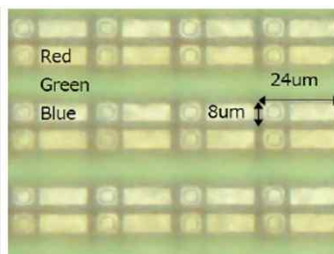
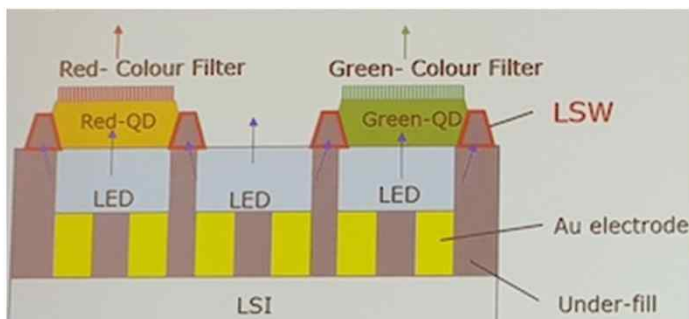


Table 2. Specification of Silicon Display

Item	Specification	
Screen size	0.38 inch	
Pixel density	1,053 ppi	
Resolution (number of dots)	209,088 sub-pixels (H:352 x RGB x V:198)	
Pixel size	24 x 24 μm^2	
Brightness*	1,000nits	
Color coordination (x,y) in CIE1931	Red	(0.620, 0.308)
	Green	(0.208, 0.645)
	Blue	(0.146, 0.040)
Color gamut (x,y)	v.s. BT2020	63.7%
	v.s. NTSC	85.3%
	v.s. sRGB	120.5%

*Driving condition: 165mA, 60 frame/sec and fully lit up conditions.

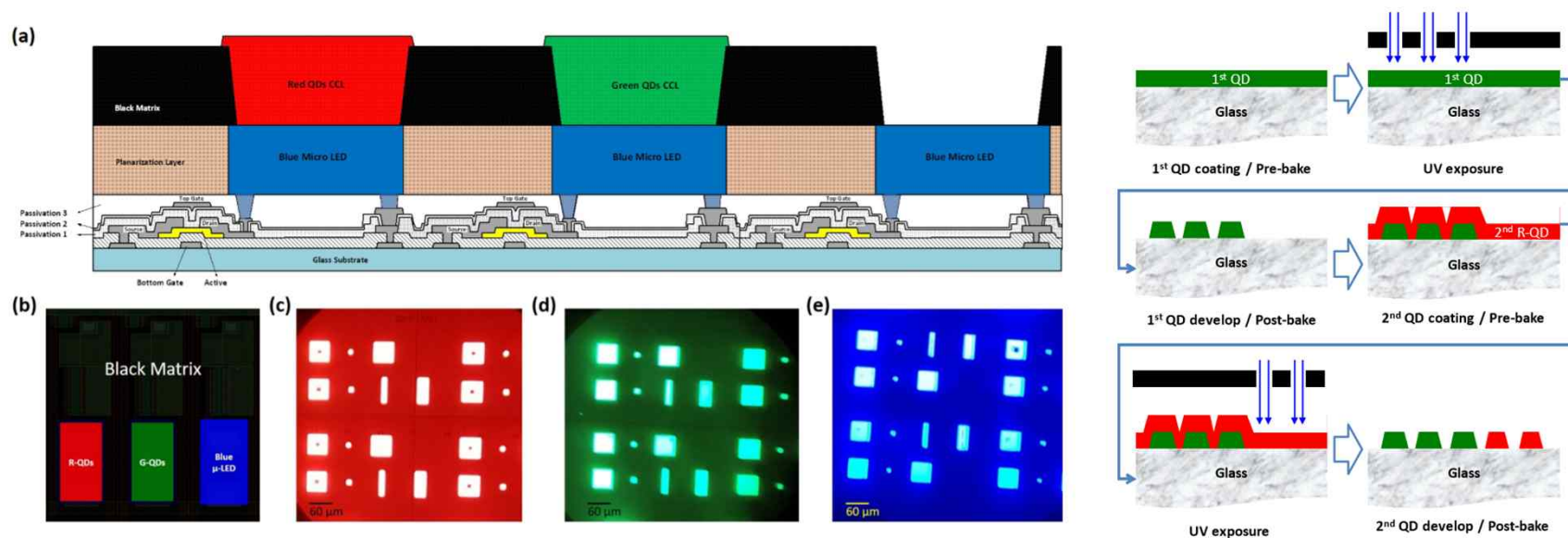
Reference : Hiroaki Onuma, et. al., "1,053 ppi Full-Color "Silicon Display" based on Micro-LED Technology" SID 2019, Sharp Corporation

Pixelization

10 μm MicroLED + G/R QDs (ADRC Kyung Hee Univ.)

Negative QD photo-resistor for fine pattern QD CCLs.

- PGMEA is used as main solvent in photo-resistor
- In dispersants, the additives, photoinitiator and curable resin are mixed together to activate photosensitive performance.
- The QDs CCLs could be patterned down to 10 μm pixel size successfully

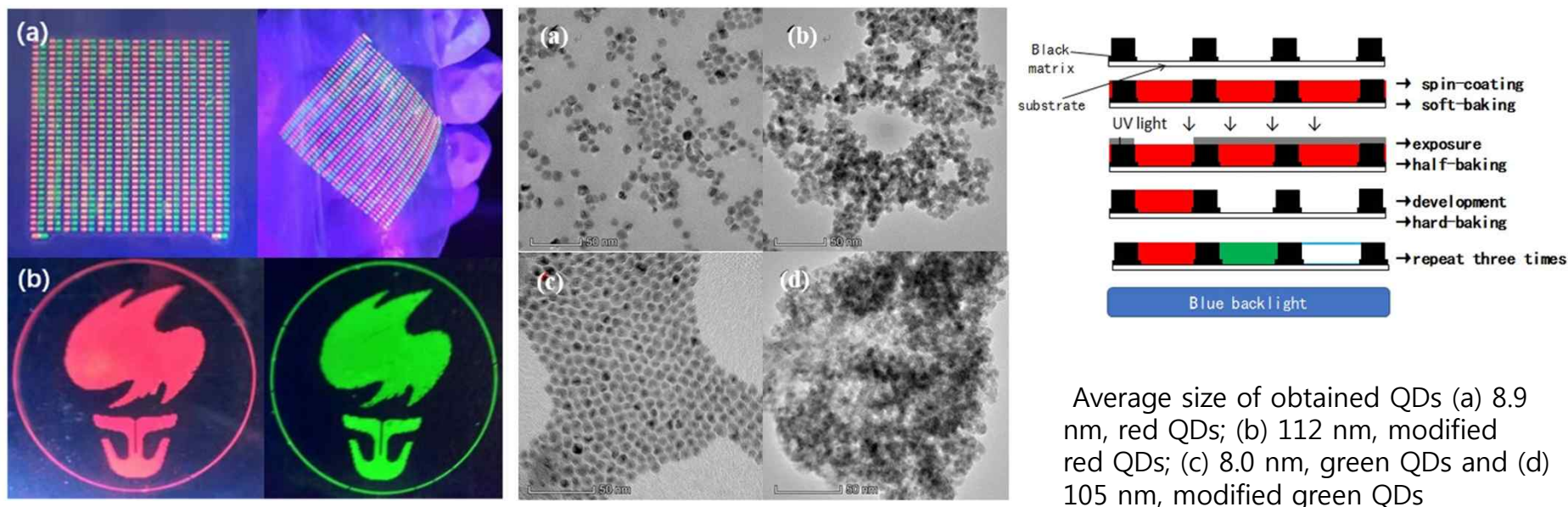


Reference : H.M Kim, et. al., "10 μm Pixel, Quantum-dots Color Conversion Layer for High Resolution and Full Color Active Matrix Micro-LED Display" SID 2019, ADRC Kyung Hee Univ., TAKOMA Co.,Ltd, HunetPlus Co.,Ltd, ZEUS Co., Ltd, KOPTI

Pixelization

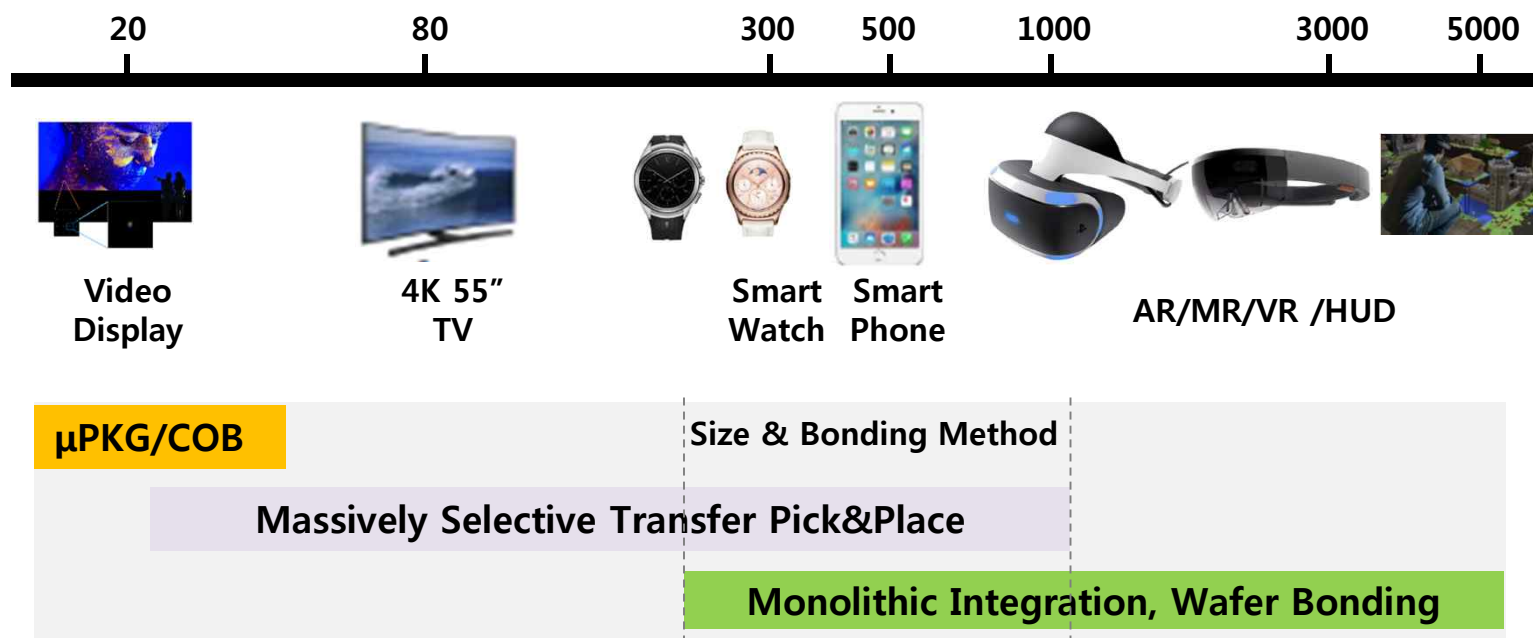
Modified QD (Southern University of Science and Technology in China)

- Higher quantum yield up to 60%-70%, and a high optical density over 1.5. Author
 - Solving the problems of QD's solubility in photoresist and its adhesion to the substrate of PET
 - The original QDs with emission peaks of 625 nm (FWHM=30 nm, QY=88 %) and 520 nm (FWHM=50 nm, QY=81 %), respectively, while the peaks change to 629 nm (FWHM=30 nm, QY=78 %) and 527 nm (FWHM=44 nm, QY=64 %) after modification, respectively.

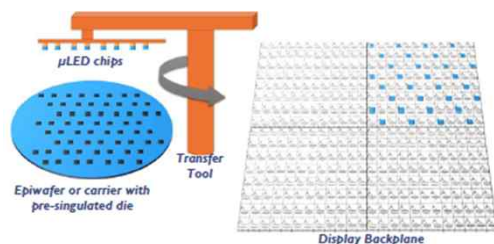


Reference : X. Bai, et. al., "Flexible Quantum Dot Color Converter Film for Micro-LED Applications " SID 2019", Southern University of Science and Technology, Shenzhen Planck Innovation Technologies Co. Ltd., Department of Chemistry.

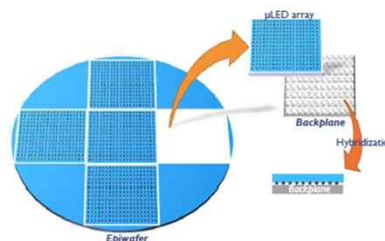
Assembly Technologies



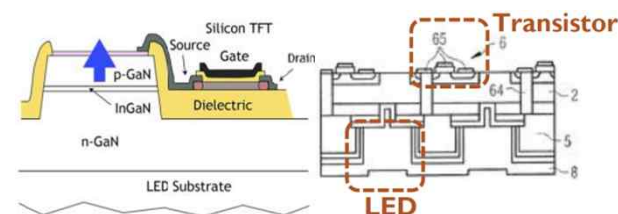
[Selective Transfer Printing]



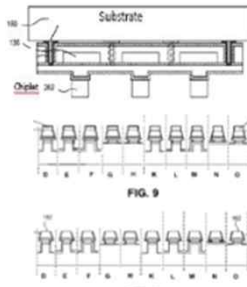
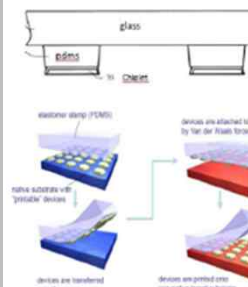
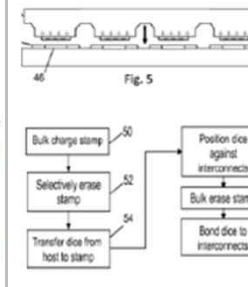
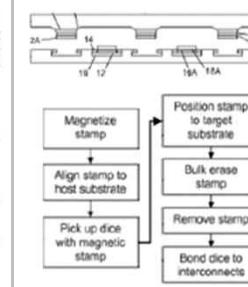
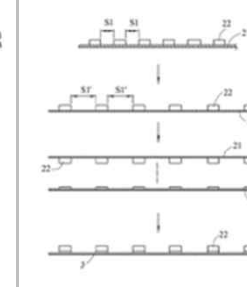
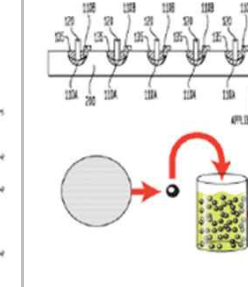
[Wafer Bonding]



[Monolithic Integration]



Assembly Technologies

	Electrostatic MEMS	Elastomer Stamp	Electrostatic Stamp	Magnetic/Electromagnetic	Adhesive	Fluidic Assembly
Company	LuxVue-Apple	UIUC, X-celeprint, Semprius, Cooledge, AUO, CSOT, ITRI	Cooledge, AUO	PlayNitride, ITRI, Cooledge	Playnitride, Intel	Nth degree, Sharp, PSI
Principle (Patent)	 <p>FIG. 9</p> <p>FIG. 9'</p>	 <p>glass</p> <p>stamp</p> <p>chip</p> <p>devices are attached to stamp by Van der Waals forces</p> <p>native substrate with predefine devices</p> <p>devices are transferred onto the stamp</p> <p>devices are printed onto destination target substrate</p>	 <p>Fig. 5</p> <p>Bulk charge stamp</p> <p>Selectively erase stamp</p> <p>Transfer die from host to stamp</p> <p>Position die against interconnects</p> <p>Bulk erase stamp</p> <p>Bond die to interconnects</p>	 <p>Magnetize stamp</p> <p>Align stamp to host substrate</p> <p>Pick up dice with magnetic stamp</p> <p>Position stamp to target substrate</p> <p>Bulk erase stamp</p> <p>Remove stamp</p> <p>Bond dice to interconnects</p>	 <p>chip</p> <p>stamp</p> <p>substrate</p>	 <p>APPLIED FIELD</p>
Core Tech.	Electrostatic pick up head	Van Der Walls force, PDMS	Transfer stamp, Electrostatic charge	Magnetic coating on chip	Stretchable adhesive film	uLED in a suspension, aligned with a EM field

Assembly Technologies

Players

1. Pick-and-place transfer (Samsung, Sony)
2. Electrostatic MEMS (Apple/Luxvue)
3. Electrostatic stamp (Cooledge, AUO, Vuereal)
4. Elastomer stamp or roll (X-Celeprint, ITRI, KIMM)
5. Ultrasonic/acoustic roll (Innovasonic)
6. Magnetic/electromagnetic stamp (ITRI)
7. Adhesive stamp (Playnitride, Intel)
8. Mechanical transfer (Rohinni)
9. Thermo-mechanical laser transfer (Uniqarta, QMAT, KOPTI, Hansol)
10. Laser ablation transfer (Optivate, KOPTI, Hansol)
11. Fluidic self-assembly (Nth degree, Sharp, PSI)

Challenges

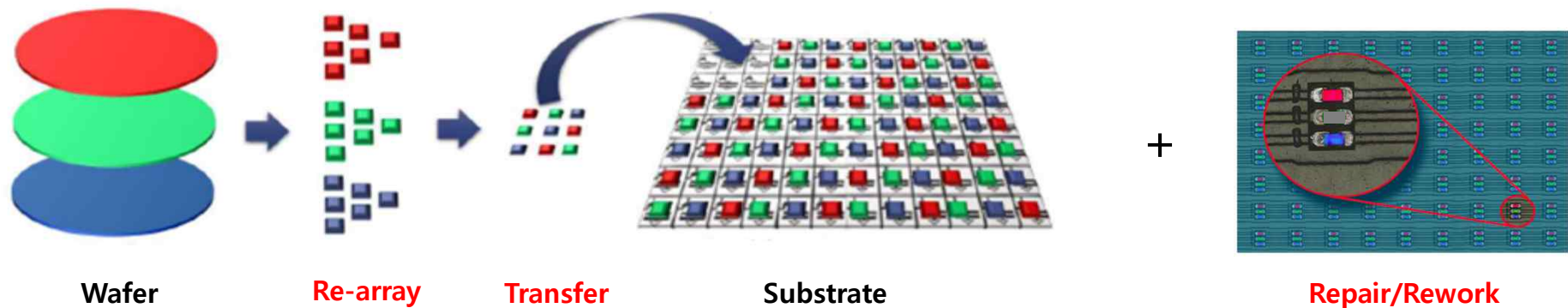
1. Efficient pick up → selecting chips
→ placement for various different pixel density
2. Ultra-high transfer yield requirements :
99.9999999%(no dead pixel)
3. Throughputs requirements are Millions dies/s
4. Very high precision of placement (within 1 μm)
5. Effective (in-situ) inspection/testing methods
6. Smart rework, sufficient redundancy scheme

Feature/ Technology	MEMS	Mechanical (pin)	Elastomeric stamp	Laser- assisted	Ultrasonic- assisted	Fluidic self- assembly
Reliability	Moderate	High	Moderate	High	High	Low
Throughput	High	Low	Moderate	High	High	High
Scalability	Low	Low	High	High	High	High
Selectivity	High	High	Low	High	High	Moderate
Success probability	Low	Moderate*	Moderate	High	High	Low

Test & Repair

Defect & Transfer Yield

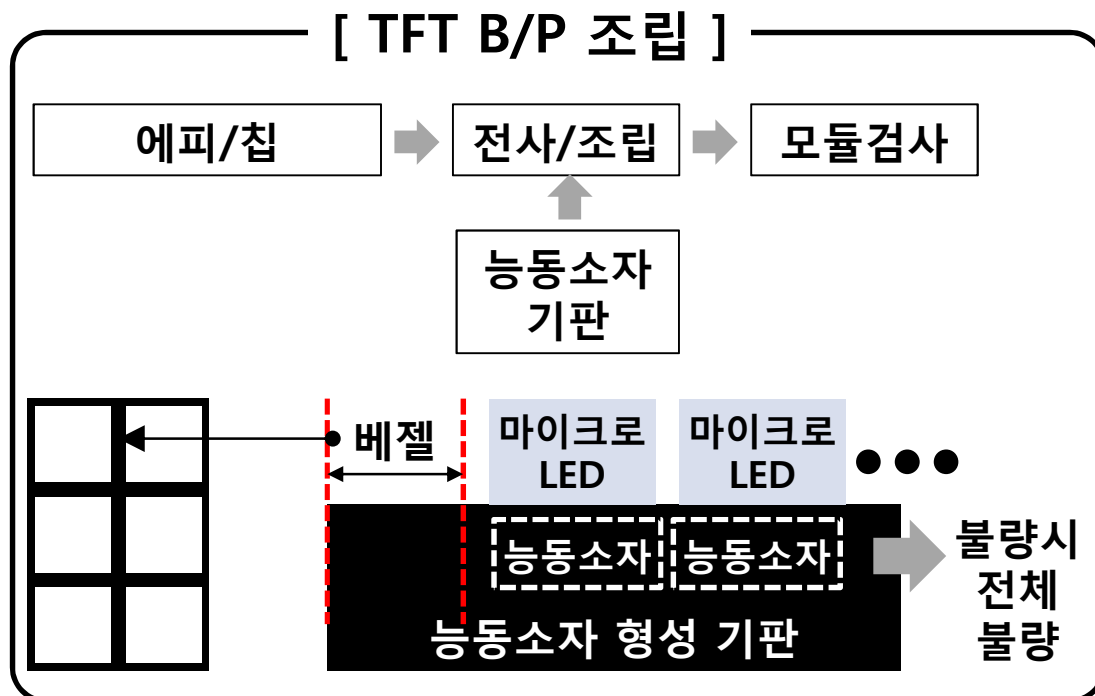
- Missaligned, Not melt solder/bump for electrical connection
 - FHD 99.9% Yield → defect 6,221 ea
 - UHD 99.9% Yield → defect 24,883 ea
- Chip removal → Residue solder removal → Solder paste by transfer pin → chip placing → curing by air heat
 - 1min. of Repair time → FHD 0.1% fail(4.32 days), UHD 0.1% fail(17.28 days)



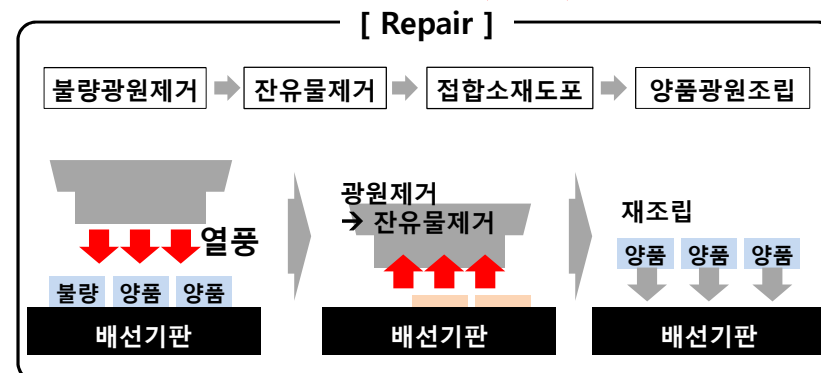
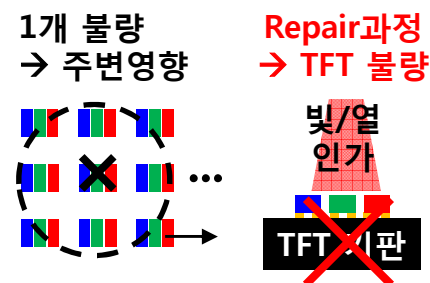
Test & Repair

Before Transfer Printing, Using Good Die Information

- The uncertainty of PL inspection result in the increase of production cost → EL Inspection
- The failure may occur on repair process because of removing of small pixel size, rearrange of good die etc.
- The extraction method of well-known good die information can be helpful used in associated with transfer process



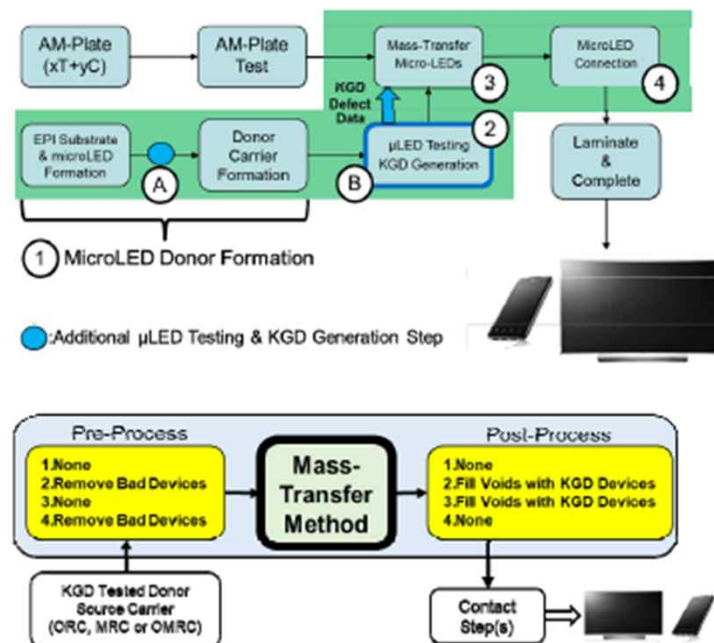
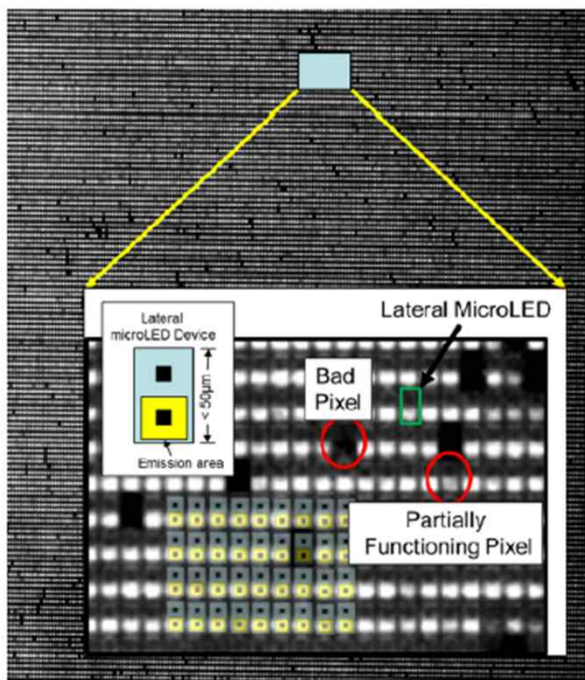
인접광원과 TFT기판 불량 (2회이상 불가)



Test & Repair

Integration of in-process EL functional test into the mass-transfer assembly process flow (Remove Bad Dies → Only Known Good Die Transfer → Repair)

- The test concept is to drive each microLED device in a massively parallel fashion without direct electrical contact to measure the light generation capability of each microLED
- EL test response of over 55,000 lateral microLEDs measured in less than 5 seconds resulting from the injection and measurement of a lateral microLED device array on an EPI growth substrate



For parallel contact with EL Method



Should support the structure of MicroLEDs Epi. and Chip



Commonization of anode or cathode ??

Reference : Francois J. Henley, "Evaluating In-Process Test Compatibility of Proposed Mass-Transfer Technologies to Achieve Efficient, High-Yield MicroLED Mass-Production, Tesoro Scientific, Inc., Saratoga CA

Test & Repair

- Integration of in-process EL functional test into the mass-transfer assembly process flow (Remove Bad Dies → Only Known Good Die Transfer → Repair)

	Mass-Transfer Technology	Companies	MicroLED Selectability	Donor Carrier Type	Required Pre-Process	Required Post-Process	Throughput	Mass-Transfer Process Flow	MicroLED KGD-Driven Production Compatibility
1	Single Pick & Place (Active)	Ex. Hsion GS100BH	Yes	MRC	None	None	Very Low (<0.1M/Hr)	1	Compatible Software Selectable Display Array Setup
2	Array Pick & Place Stamp (Passive)	Xceleprint, Apple & Others	No (3-step)	OMRC	Remove Bad Devices or KGD Source Carrier	Requires KGD Fill Step or KGD Source Carrier	Low (~1-20M/Hr)	2	Less Adaptable (3-step)
3	Array Pick & Place Stamp (Active)	Apple (Luxvue)	Yes (2-pass)	MRC	None	KGD Fill Step (2nd pass)	Low (~1-20M/Hr)	3	Less Adaptable (2-step)
4	Roll-Roll (Passive)	KIMM	No (3-step)	OMRC	Remove Bad Devices or KGD Source Carrier	Requires KGD Fill Step or KGD Source Carrier	Medium-High (~10-50M/Hr)	2	Less Adaptable (3-step)
5	Self-Assembly (Passive)	eLux, SelfArray, NthDegree, PSI Co.	No (2-step)	ORC	Isolate KGD Devices	None	High (>50-100M/Hr)	4	Adaptable (KGD Pre-Binning)
6	Single-Beam Laser-Induced Forward Transfer (LIFT) (Active)	V-Technology Co., Ltd.	Yes (2-pass)	ORC	None	KGD Fill Step (2nd pass)	Potentially High (>50-100M/Hr?)	3	Adaptable (2-pass) Direct GaN Decomposition Unproven for Throughput/Yield
7	Array Laser-Induced Forward Transfer (Passive)	Coherent, Uniqarta	No (3-step)	ORC	Remove Bad Devices or KGD Source Carrier	Requires KGD Fill Step or KGD Source Carrier	Potentially High (>100M/Hr)	2	Less Adaptable (3-pass & Product-Specific Hardware Setup)
8	Single-Beam Laser-Assisted KGD "on-the-fly" Directed Assembly Architecture	Tesoro Scientific Inc. Smart-Assembly	Yes 1-pass possible (Active)	ORC	None	Reduce/Eliminate Device Fill Step	Very High (>200-500M/Hr)	1	Compatible Software Selectable Display Array Setup

Table 1: Compatibility and Manufacturing Complexity Comparison of Various Mass-Transfer Approaches.

Transparent MicroLED Displays

MicroLEDs on IGZO Oxide TFT Panel (CSOT)

- **Active matrix mini-LEDs full color display with high transmittance over 60%.**
 - Achieved over 114% NTSC color gamut with RGB flip chip mini-LEDs (100 um X 200 um)
 - The display has a high aperture ratio pixel of about 82%.
 - The area ratio of the mini LED chip is just about 6.5% in the pixel, RGB pixel size 0.55mm.

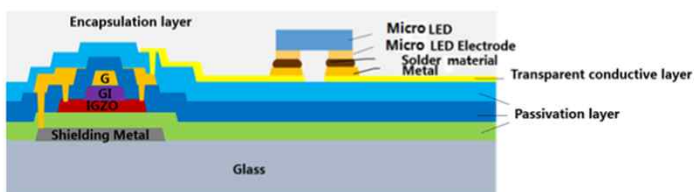


Figure 1: The Structure of the 8 inch transparent AM mini-LEDs panel



	Wp/FWHM	X	y
R	628/15	0.6915	0.3079
G	525/27	0.1965	0.7458
B	470/17	0.1219	0.0804
NTSC(Area)	114.2%		
NTSC(Coverage)	99.7%		
Transmittance	60.4% (Base on YAG LED Backlight)		

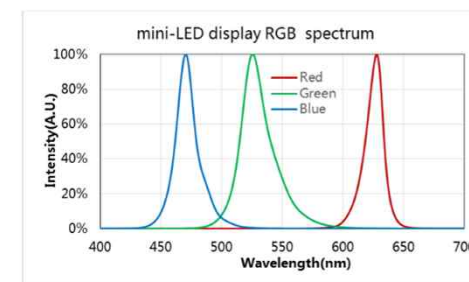
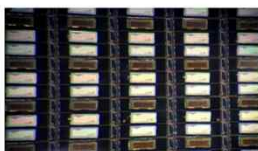
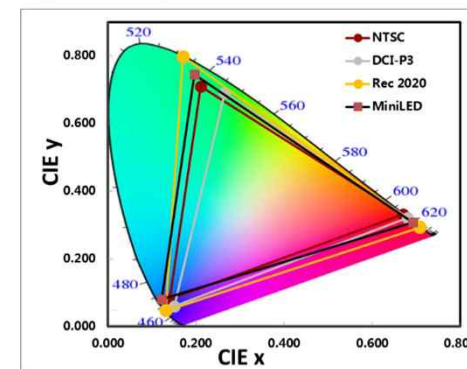


Figure4: The spectrum of RGB micro-LEDs



Reference : Jack Fan, et. al., "High transparent Active matrix Mini-LED Full Color Display with IGZO TFT Backplane" SID 2019, Shenzhen China Star Optoelectronics Semiconductor Display Technology Co., Ltd.. Shineon (Beijing)Technology Co., Ltd.

Transparent MicroLED Displays

[Playnitride : SID 2019]

Active Matrix 7.56" LTPS, 60%
720 x 480, 114ppi, 600nits



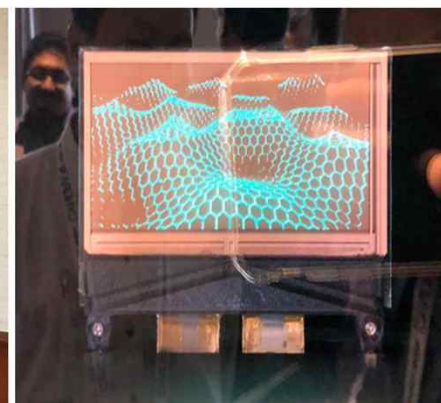
Driving	Active Matrix
Panel Size	7.56"
Resoultion	720 x 480
Pixel Density	114 ppi
Brightness	> 600 nits
NTSC	116%
Transprancy	> 60%
Border Width	< 0.7 mm

[TIANMA : SID 2019]

7.56" full color transparent
LTPS backplane



[X-display(X-Celeprint)]



5.1" 70PPI
Up to 30,000nit
developing

Backlight Unit

High Quality LCD Display with White Mini-LEDs & MicroLEDs

Mini-LED Light Confinement, Optical Film, Local Dimming Technologies

- Halo effect (light leakage between adjacent black and bright pixels) can be suppressed to unnoticeable level by optimizing the LCD contrast ratio, number of local dimming zones, LED light expansion and local light confinement
- Optical microstructure film, local dimming & RGBW algorithm mini LED optical field distribution and luminous efficiency should improve the performance of HDR display for smartphone

[Local Light Confinement]

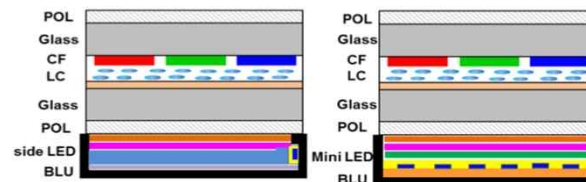
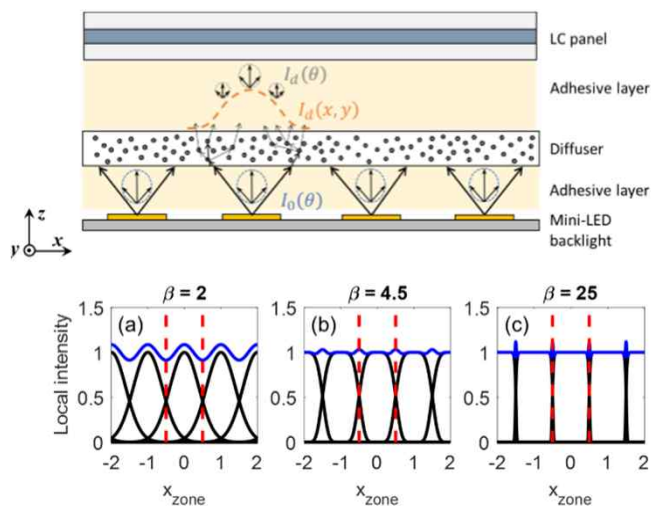
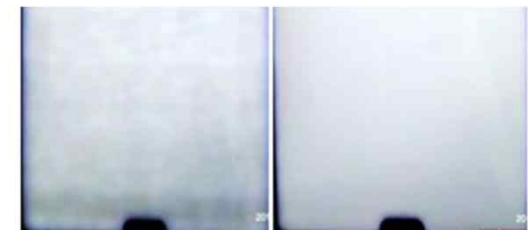
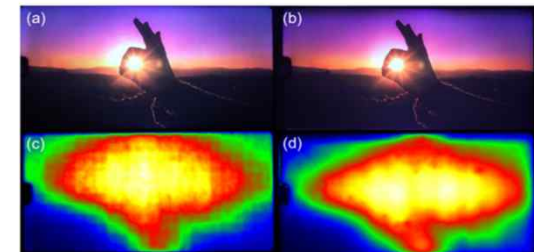


Table 2. Main parameters of normal IPS LCD and HDR LCD

Display	IPS normal LCD	HDR LCD
resolution	1080*2160	1080*2160
size	5.99	5.99
color gamut	86%DCI-P3	100% DCI-P3
peak luminance	500nits	>800nits
max contrast ratio	2000:1	>20,000:1
partition of local dimming	0	512
average power consumption	1W	1.4W

[288/512 Partitioning]



Reference : Yuge Huang, et. al., "Mini-LED Enhanced LCD for High Dynamic Range Displays" SID 2019, College of Optics and Photonics, University of Central Florida, AU Optronics Corporation, Hsinchu, Taiwan
 Binyi Zheng, et. al., "An Advanced High-Dynamic-Range LCD for Smartphones", SID 2019, Xiamen Tianma Microelectronics Co., Ltd

Backlight Unit

Mini-LEDs for Micro Display (LCoS, AUO)

Active Matrix Driving using LTPS TFT Backplane for 1,000 PPI VR LCD

- Local dimming function and switchable VR modes, high current → better contrast ratio and less motion blur, brightness Max. 130,000 nits (Normal 12,000 nits)
- Optimization of design for brightness vs. current result in IR Drop by increasing the number of mini-LEDs

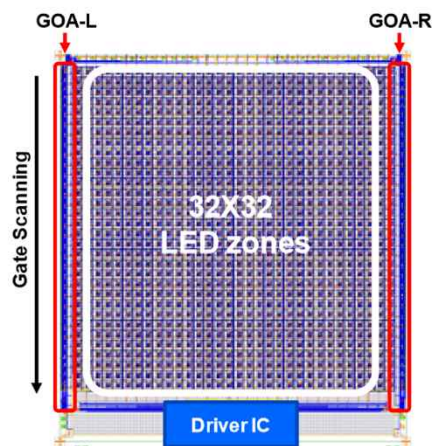


Figure 1. A schematic of AM mini-LED backlight of 32x32 LED zones.

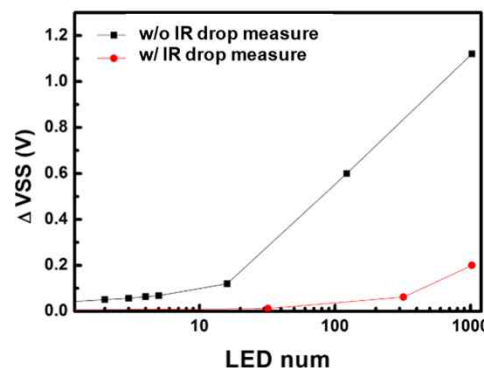
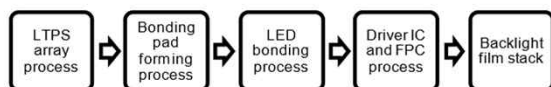


Figure 5. Improve of IR drop on AM mini-LED backlights.

	w/o action	Action 1	Action 1+2
Max. Current (mA)	112	730	1200
Max. brightness (nits)	10750	93308	130495
Current Efficiency (nit/mA)	96	128	108



Figure 6. A backplane of AM mini-LED with LEDs.

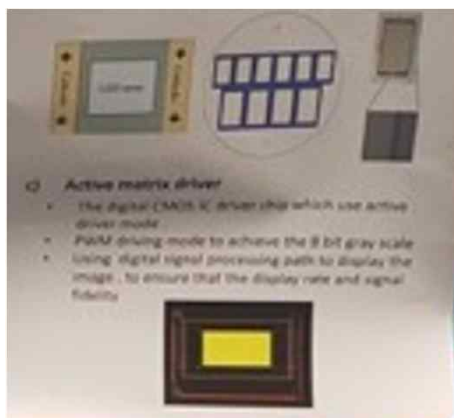


Figure 7. A 1000PPI VR LCD module with AM mini-LED embedded.

Reference : Yang-En Wu, et. al., "Active Matrix Mini-LED Backlights for 1000PPI VR LCD " SID 2019, AU Optonics Corporation, Hsinchu, Taiwan

Backlight Unit

Pennsylvania State Univ.
: Micro Display



CSOT : Smartphone,
Automotive, Monitor



JDI
: Micro Display

VR IPS

Local Dimming Backlight for VR

Ultra-high Contrast (200,000:1)

- Sharp black color with ultra high contrast
- Fine light control by applying 3840 pcs of Mini LED
- A Direct-lit LED backlight

Specification	
Size	3.5-inch
Backlight method	Local dimming
LED	Mini LED (80p × 64p 3840pt)
Segments	30 × 32 = 960 segments
Contrast	200,000 : 1
Luminance	150 cd/m ²
Color gamut	NTSC Typ. 95%
BL Thickness	1.33mm

JDI Japan Display Inc.

TIANMA
: Micro Display

TIANMA

LTPS AM Mini-LED Backlight Display

HDR LCD Technology Solutions

Technology Advantages

- High contrast 1000000:1
- Authentic image reproduction
- Finer details in low gray scale
- Vivid color reproduction
- Sunlight readable outdoors

*AM = Active Matrix
*HDR = High-Dynamic Range

PEOPLE'S CHOICE AWARDS
Nov 2016 - 2017
SID

High Resolution & Active Matrix

Active Driving → LTPS / Oxide TFT Vs. Micro IC

- Automotive Product for High Reliability

SID 2018



- 8" micro-LED Display
- LTPS TFT B/P
- 169 ppi (chip size : 30um)
- Full-color : Blue LED + Color conversion mat'l

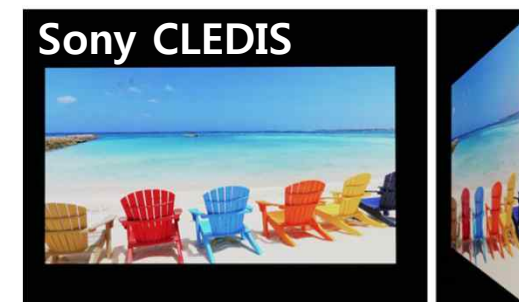


- 5.1" full-color display
- 8 um x 15 um chip, 70 ppi
- micro IC for active matrix driving

SID 2019



-12.1", 700 nits



-1,000 nits
- 20 PPI

High Resolution & Active Matrix SID 2019

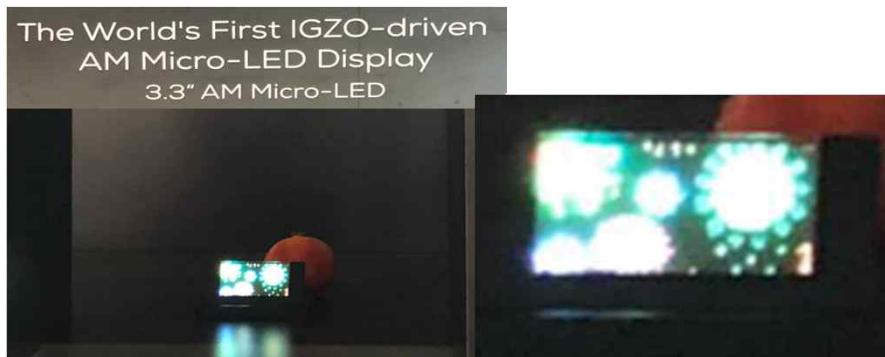
Active Driving → LTPS / Oxide TFT Vs. Micro IC

[ITRI]



- 40 PPI, 6 Cm X 10 Cm
- Micro LED on PCB and PI.
- Direct transferring RGB Micro LED chips to PCB backplane in volume

[NATIONSTAR]

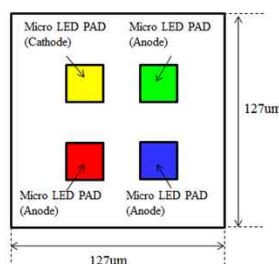
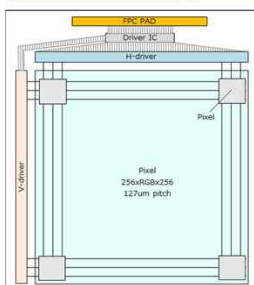


- 3.5" full color transparent.
- IGZO glass backplane with active matrix driven solution.

High Resolution & Active Matrix

Active Driving : LTPS TFT, 200 PPI, 1.8 inch size for HUD or AR

- A dot pitch of $127 \times 127 \mu\text{m}$ (200 ppi) by optimizing the layout of LED-mounted pads of each of RGB according to the pixel size, and also by optimizing the pattern layout of the pixel circuit and peripheral circuit formed by LTPS in the lower layer of each LED PAD.



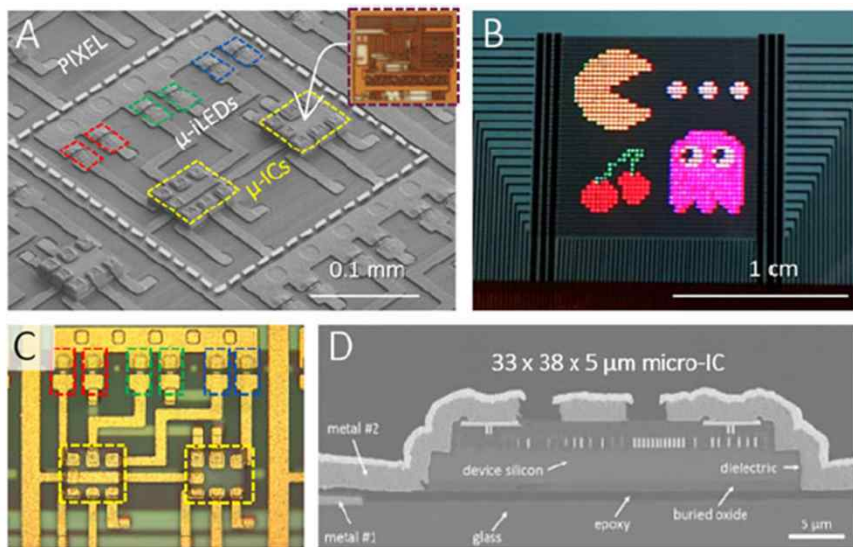
Category	Item	Condition	Result	Remark
Display spec.	Number of dots	-	256 x 256 RGB	
	Dot pitch	-	$127 \times 127 \mu\text{m}$	200 ppi
	Display size	-	1.8 inch	
	Active area	-	$32.5 \times 32.5 \text{ mm}$	
	Optical device	-	Micro LED	RGB independently emission
Optical spec.	Brightness	25 degree C White image	984 cd/m^2	
	Contrast	25 degree C	More than $1,000,000 : 1$	
	Gray scale	-	8 bit full color	
	Color reproducibility	984 cd/m^2 White = D65	117 % 88 %	NTSC ratio Rec.2020 ratio
	Response time	-30 to 80 degree C	Less than 1 ms	
	Viewing angle	Contrast > 10,000	More than 178 degree	
Electronic spec.	Operating temperature	-	-30 to 80 degree C	
	Frame rate	-30 to 80 degree C	240 Hz	

Reference : Sho Nakamitsu, et. al., "High PPI Micro LED Display for Small and Medium Size " SID 2019, Kyocera Corporation, Yasu, Japan

High Resolution & Active Matrix

Active Driving → Micro IC

- Carry out selective pick-Transfer-Place and bonding process on high precision patterned backplane and then the passivation layer is deposited on them
- Through the sputtering and photolithography process, the interconnect vias and traces are selectively formed



X-celprint

- 5.1" full-color display
- 8 μ m x 15 μ m chip, 70 ppi
- micro IC for active matrix driving
- stamp size : 15mm (yield : 99.99%)



High Resolution & Active Matrix

Active Driving → Micro IC (Sony CLEDIS)

- Active matrix driving : Integrating RGB micro LEDs and a micro IC in each pixel
 - The passive-matrix driving in a large scale display system → High current densities, Impedance mismatching, Cross talks between lines → These issues give rise to limitations such as resolution, brightness, reliability, and motion picture quality.

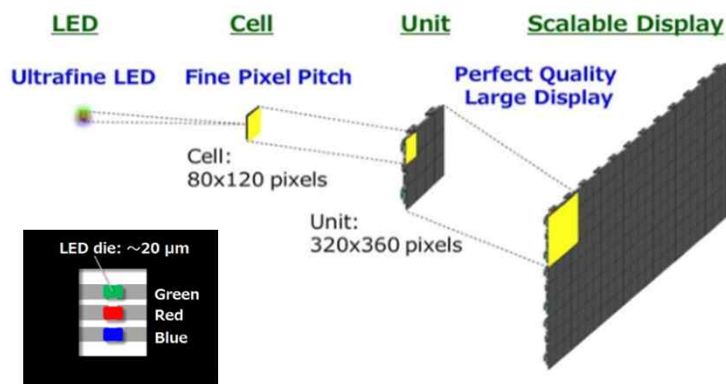
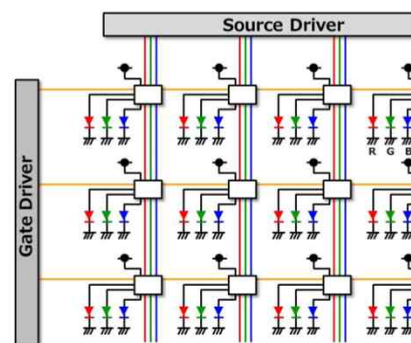
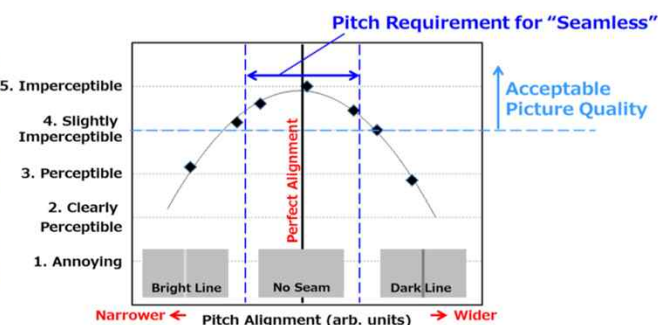


Table I. Features of Crystal LED display system.

Brightness	1,000 cd/m ²
Pixel Pitch	1.26 mm
Native Color Space	140 % of sRGB (u'v')
Frame Rate	up to 120 fps
Viewing Angle	almost 180 degrees



Psychophysical Test (Subjects of 12 Persons)

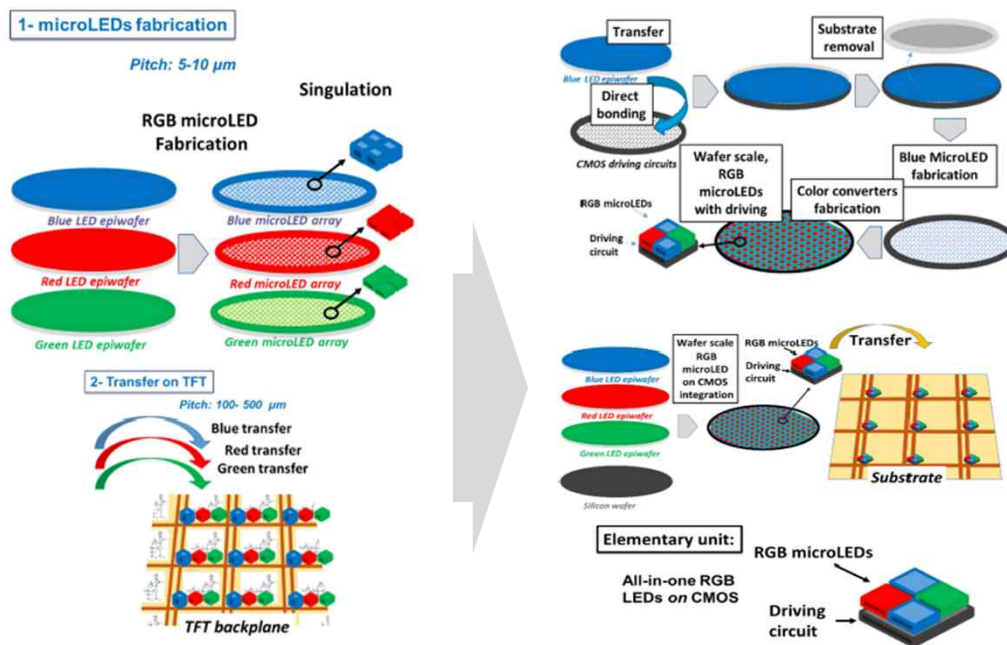


High Resolution & Active Matrix

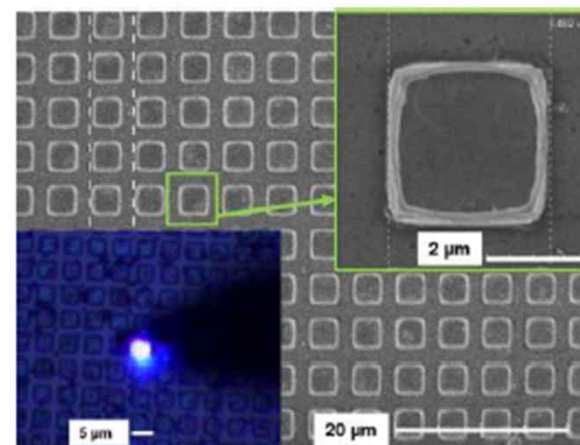
■ Active Driving → CMOS Circuit Substrate likely Micro IC (CEA-LETI)

● AM-WLP(Wafer Level PKG) : RGB Chip on a CMOS sub

- Active Matrix Solution → The receiving part is no more a TFT B/P → a simple, low-cost receiving substrate (Transfer Printing Process, The Kinds of B/P Loss etc.)
- CMOS Driving provide more HDR (High Dynamic Range) than TFT → High Quality Brightness



Non-lithographic techniques → Low cost
Free of TFT Process → No size limit
Rigid/flexible Material → Freedom of material

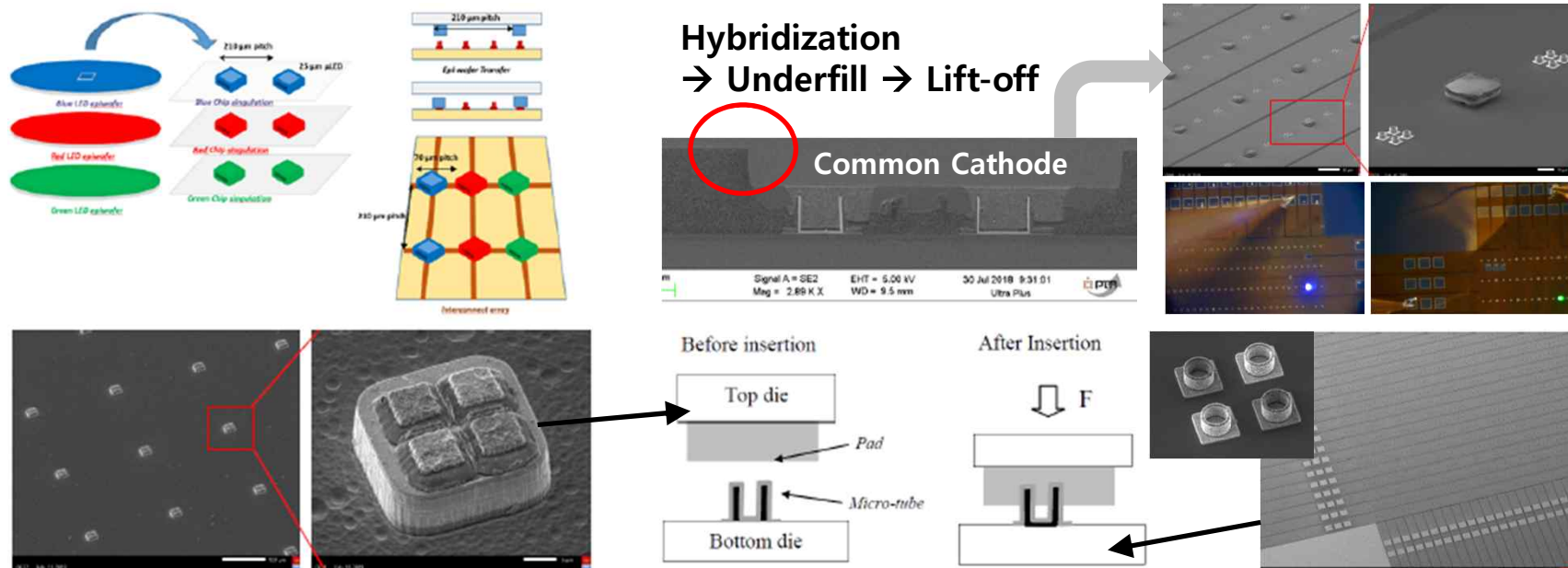


Reference : F. Templier, et. al., "A New Approach for Fabricating High-Performance MicroLED Displays, Grenoble Université Alpes, CEA-LETI, France

High Resolution & Active Matrix

Microtube Interconnection (CEA-LETI, 100 ~ 120PPI RGB Solution)

- Growth of blue & green Epi. in a silicone wafer (4", 25 μ m \times 25 μ m \times 5 μ m)
 - Fabrication of a blue and a green prototype with 40 x 40 pixels, 210 μ m pitch on passive matrix.
- Passive matrix by using conventional CMOS process on 8" wafers (Tube Structure)
- Hybridization \rightarrow Remove Epi. Sub. \rightarrow Repeat Green MicroLEDs



Reference Jeannet Bernard, et. al., "MicroLED Displays based on Transfer with Microtubes Interconnections, Grenoble Université Alpes, CEA-LETI, France

■ **Mega Trend : Large Display, Automotive, Micro Display**

■ **Micro LED Cost Reduction**

→ Next Generation Display, Post-OLED

■ **Currently, Mini-LED BLU Market is started**

: Mobile → AR/VR → TVs

■ **Pixel Colorization using QD**

→ Reduction solution : increase of cost and failure probability for transfer printing process